



# Nanotechnológia

Tapasztó Levente

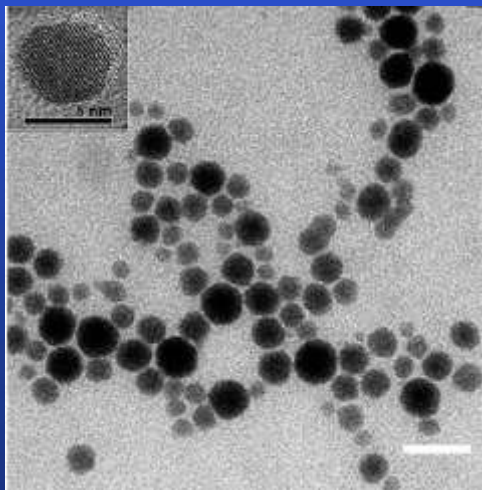
Műszaki Fizikai és Anyagtudományi Kutatóintézet

*„There's plenty of room at the bottom”*

Richard Feynmann (1959)

# Mi a nanotechnológia?

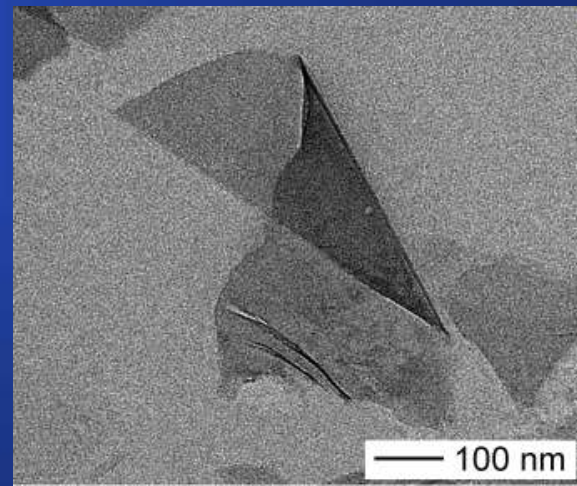
- Olyan szerkezetek (nanoszerkezetek) létrehozása, tanulmányozása és módosítása, amelyek mérete a nanométeres tartományba esik: legalább egyik dimenzióban  $< 100$  nm



Au nanorészcsek



InP nanoszálak





ZnO nanolemezek

# Miért érdekes (fontos) a nanotechnológia?

Az anyagok másként viselkednek ebben a mérettartományban:

- megváltoznak az elektromos, optikai, illetve kémiai tulajdonságaik a tömbi viselkedésükhöz viszonyítva pl. Au



| Bulk Gold  | Gold as nanoparticles   |
|--|---|
|   |    |
| <ul style="list-style-type: none"><li>•Shiny</li><li>•Always gold in colour</li><li>•Inert</li><li>•Conducts electricity</li></ul> | <ul style="list-style-type: none"><li>•Varies in appearance depending on size and shape of cluster</li><li>•Never gold in colour, found in a range of colour</li><li>•A very good catalyst</li><li>•Not a metal but a semiconductor</li></ul> |



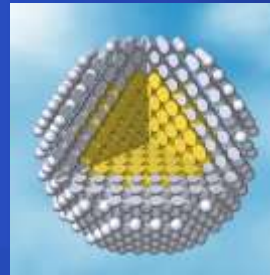
Pusztán a méretük megváltoztatásával kontrollálni tudjuk ezen tulajdonságok változását !



# Mi az oka a tulajdonságok megváltozásának?

- felületi atomok arányának drasztikus megnövekedése – kémiai tulajdons.

$$\frac{F_{gomb}}{V_{gomb}} = \frac{4\pi r^2}{\frac{4\pi r^3}{3}} \propto \frac{1}{r}$$



- kvantummechanikai effektusok – fizikai tulajdonságok

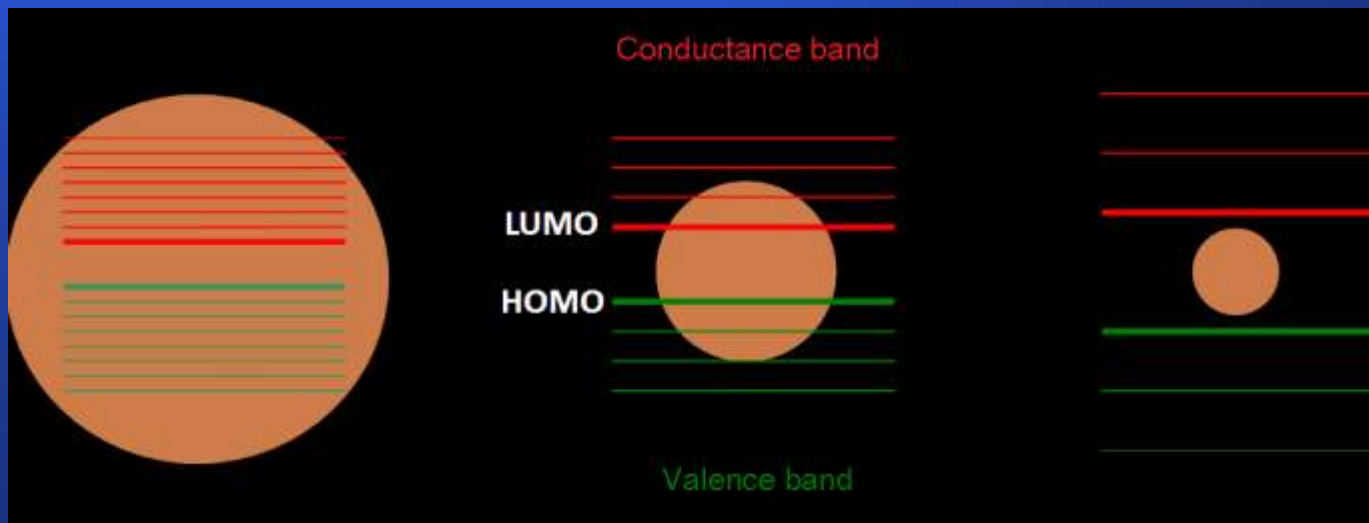
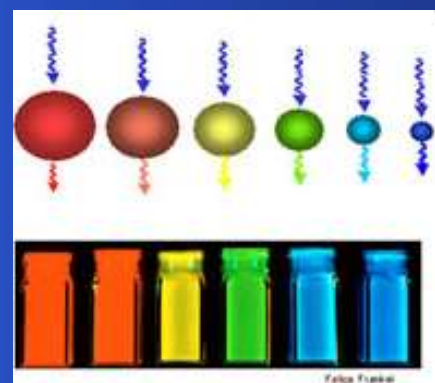
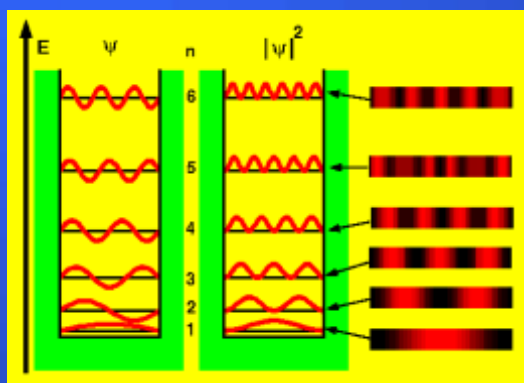
$$p = \frac{h}{\lambda} = \frac{h}{2\pi} k = \hbar k$$

$$\left( \frac{\hat{p}^2}{2m} + V(\mathbf{r}) \right) \Psi(\mathbf{r}) = E\Psi(\mathbf{r})$$

a kristályra jellemző sáv szerkezetet felülírják a mérethatások:

– kvantum-bezárttság: akkor lép fel ha az elektronok koherenciahossza összemérhető a szerkezet méreteivel – interferencia hatások

# Kvantum-méret hatások



a kristályra jellemző sávszerkezetet felülírják a mérethatások

# Nanoszerkezetek előállítása

Számos fizikai és kémiai eljárás létezik.

Két alapvető koncepció:

**top-down**

vs.

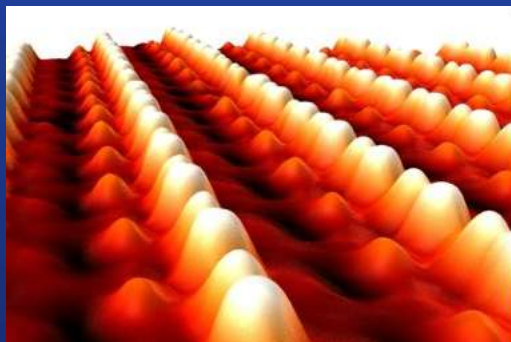
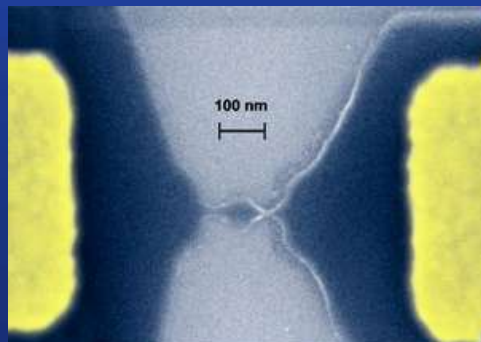
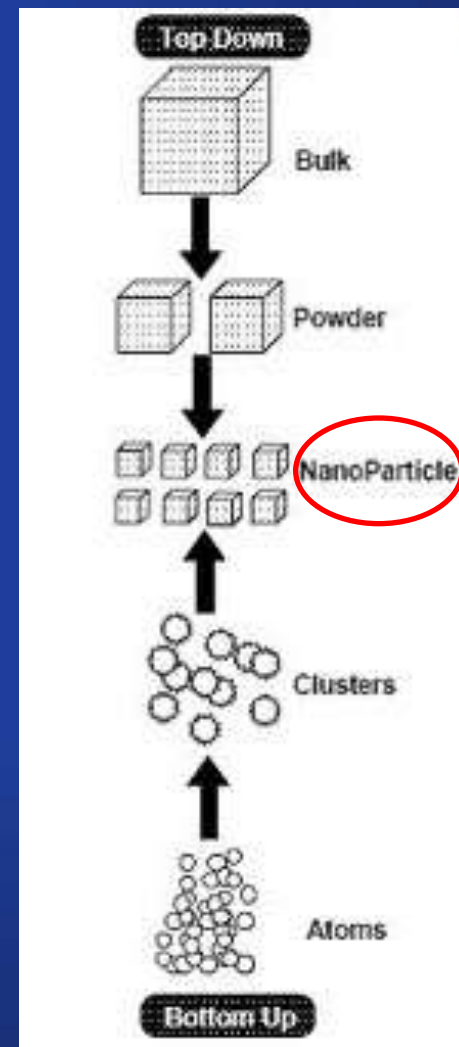
**bottom-up**

- Litográfiai eljárások

- Elektronikus eszközök

- kémiai szintézis

- önszerveződés

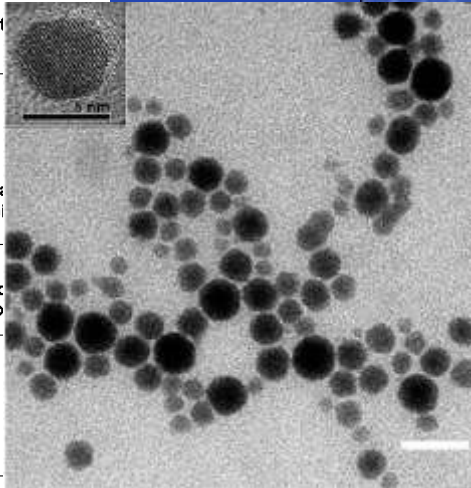
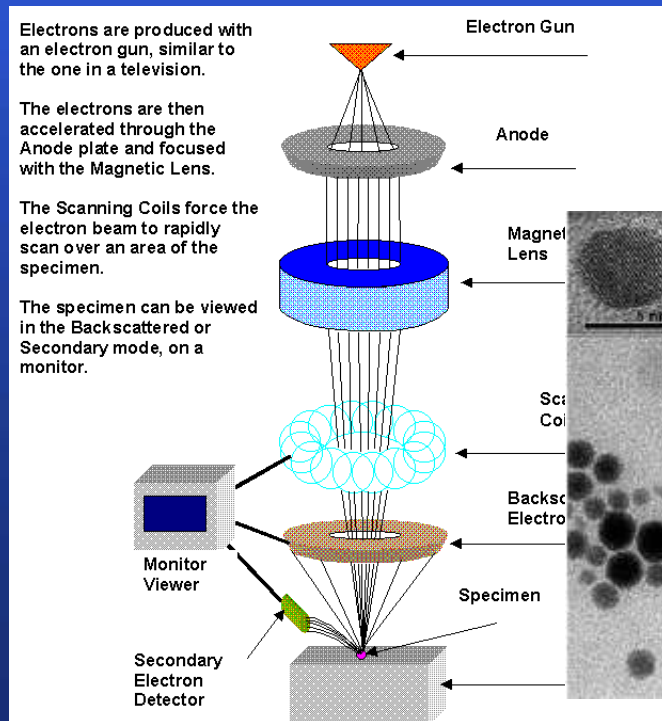


# Mivel vizsgálhatjuk a nanoszerkezeteket?

Optikai mikroszkóp: túl nagy a látható fény hullámhossza

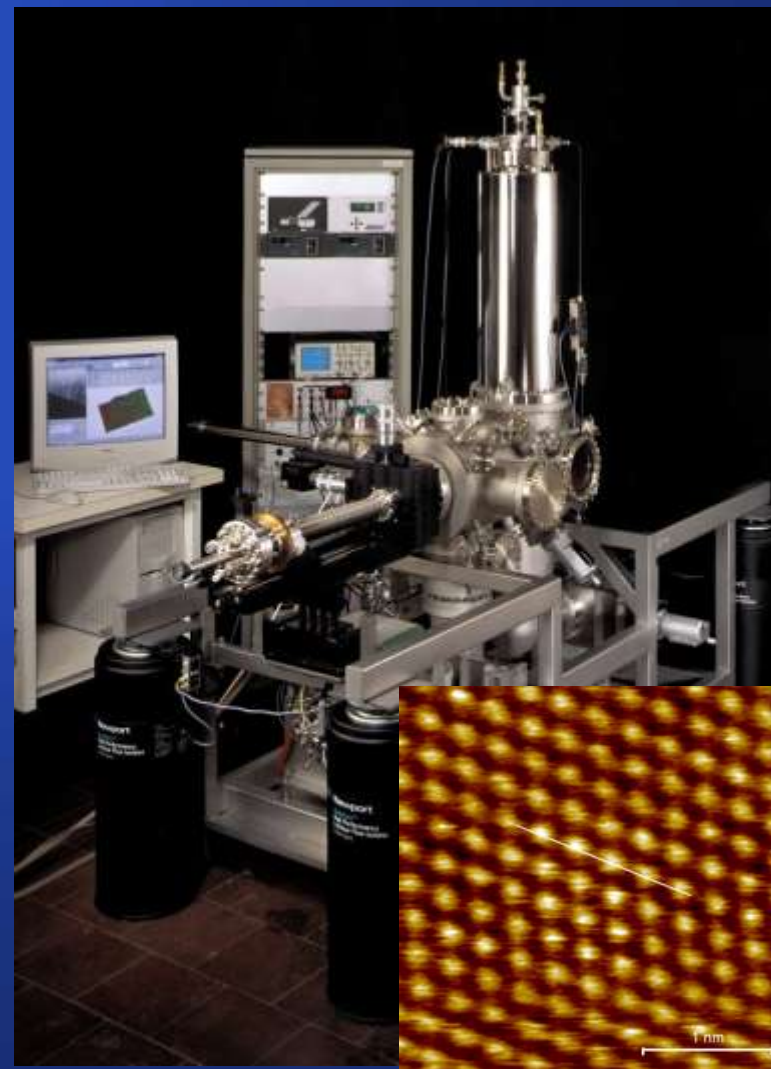
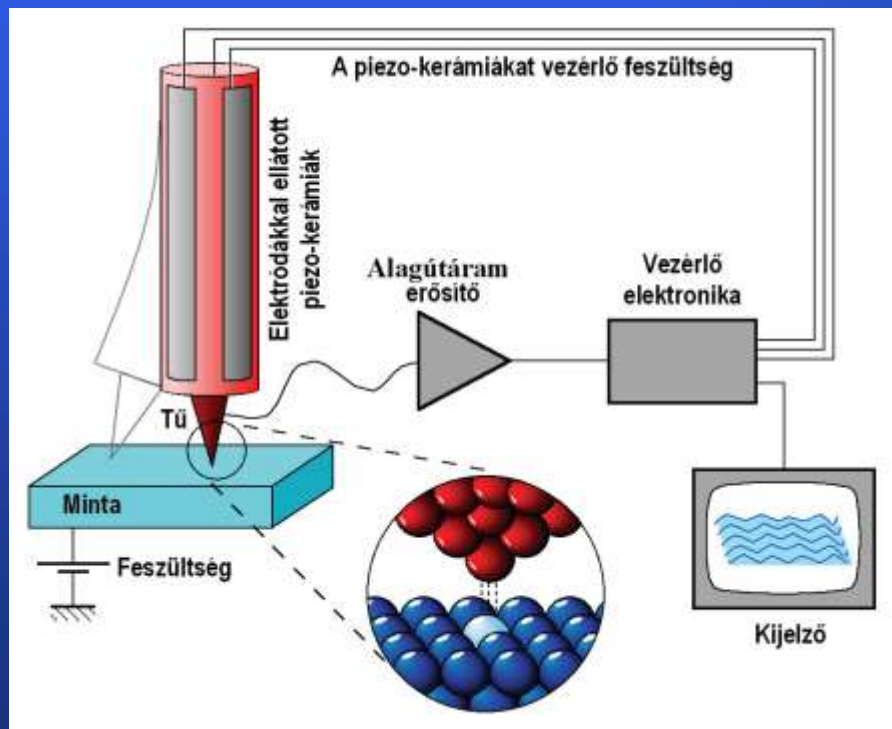
Megoldás: Elektronmikroszkóp

$$E = \frac{hc}{\lambda}$$



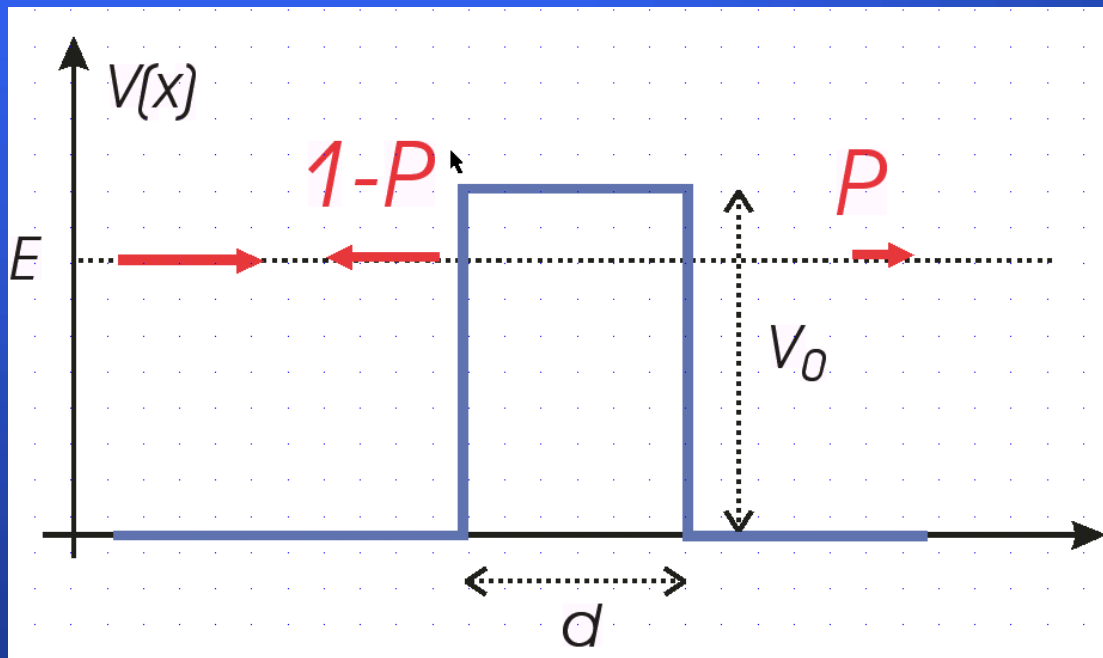


# Pásztázó alagútmikroszkóp - STM



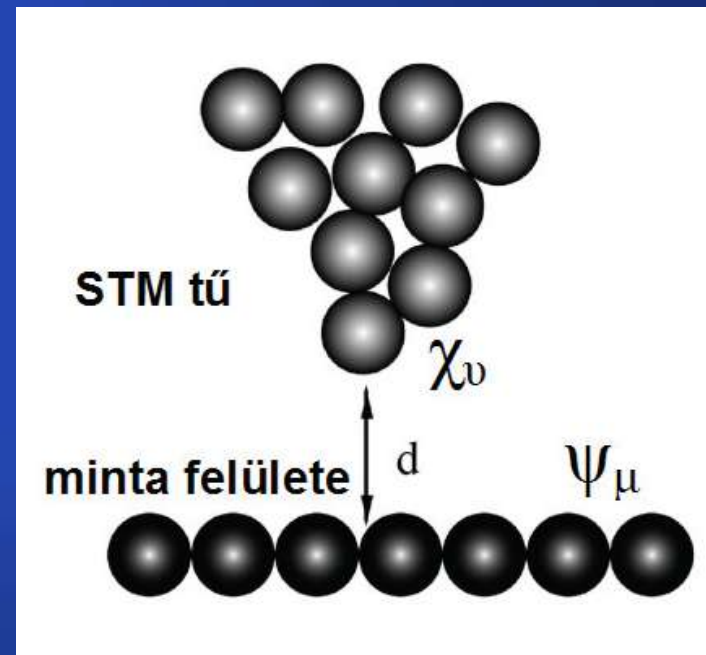


# Kvantummechanikai alagutazás



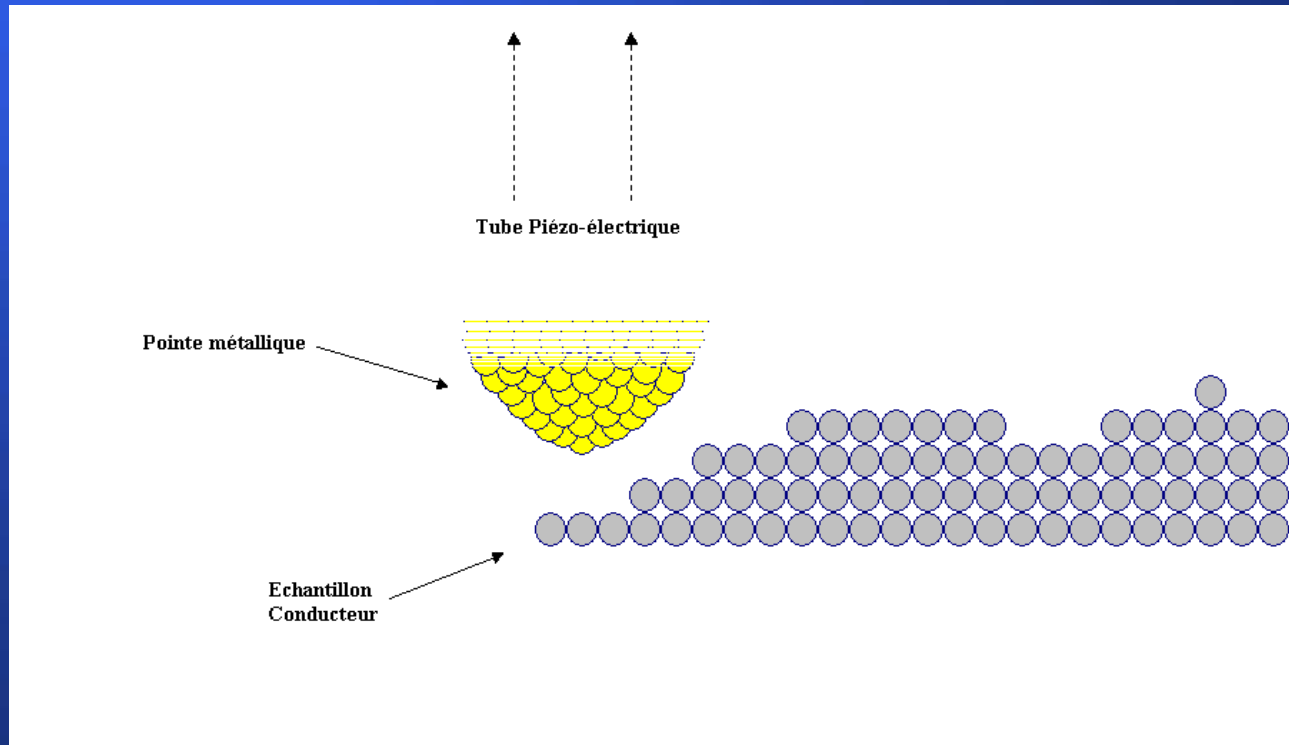
$$P \propto e^{-2\kappa d}$$

$$\kappa = \sqrt{2m/\hbar^2 (V_0 - E)}.$$

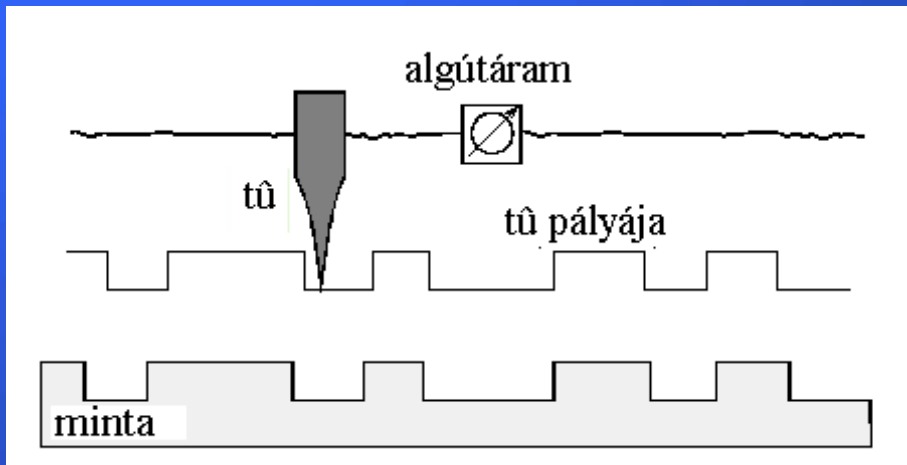


$$I \propto \exp(-2\kappa d)$$

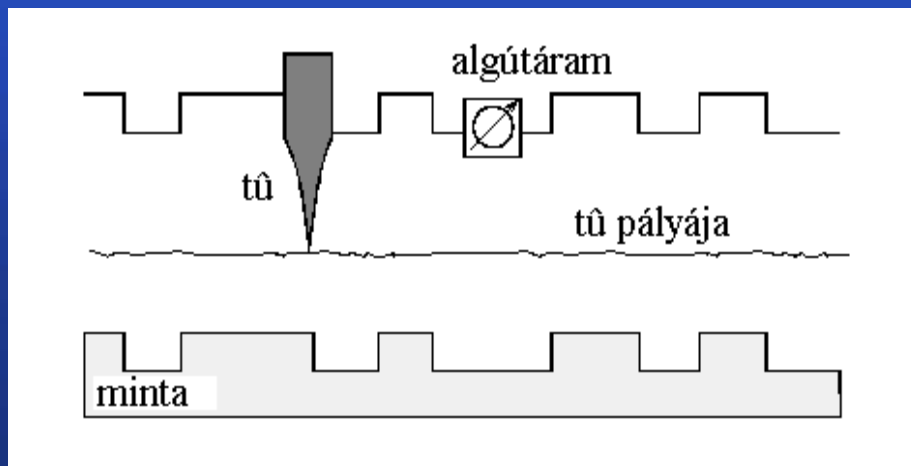
# STM animáció



# STM üzemmódok



1)  $I_t = \text{állandó}$   
(topográfiai üzemmód)

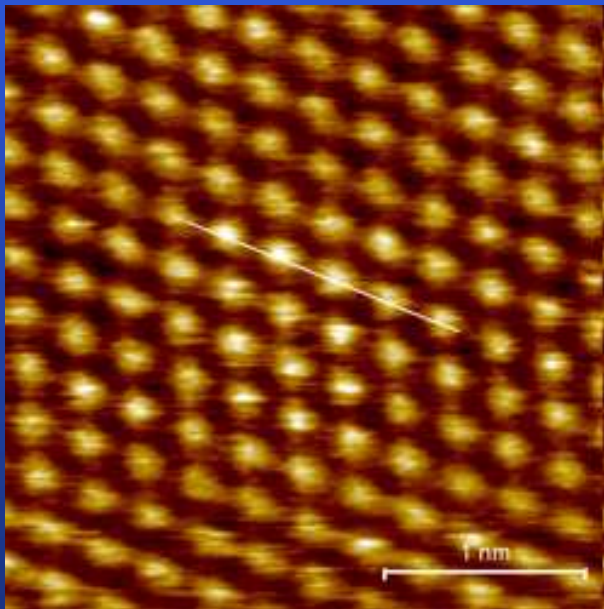


2)  $d = \text{állandó}$   
(állandó “magasság” üzemmód)

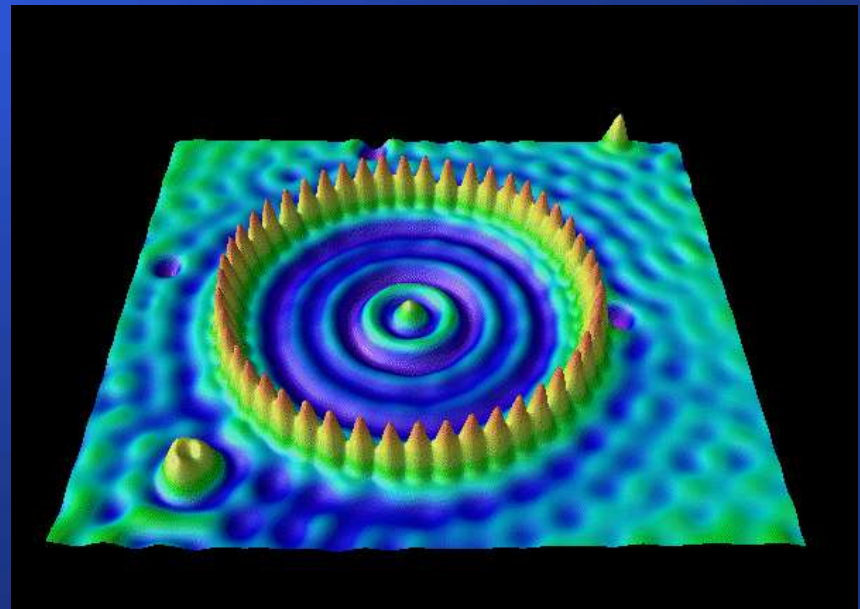
# STM elmélet

$$I_t = 2 \frac{\pi e}{\hbar} \sum_{\mu, \nu} \left| \langle \chi_\nu | V_{tunnel} | \psi_\mu \rangle \right|^2 \delta(E_\mu + eV_t - E_\nu)$$

$$I(\vec{r}) \propto \int_{E_F - eU_{bias}}^{E_F} \rho_{LDOS}(\vec{r}, E) dE$$



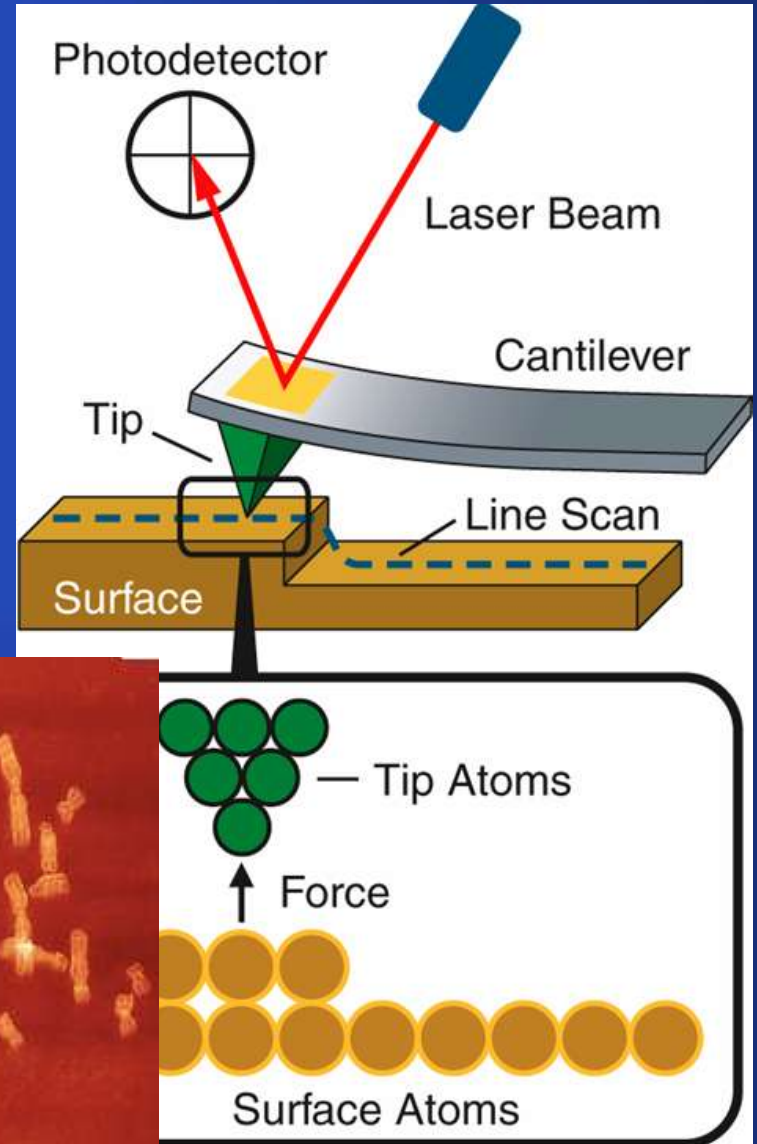
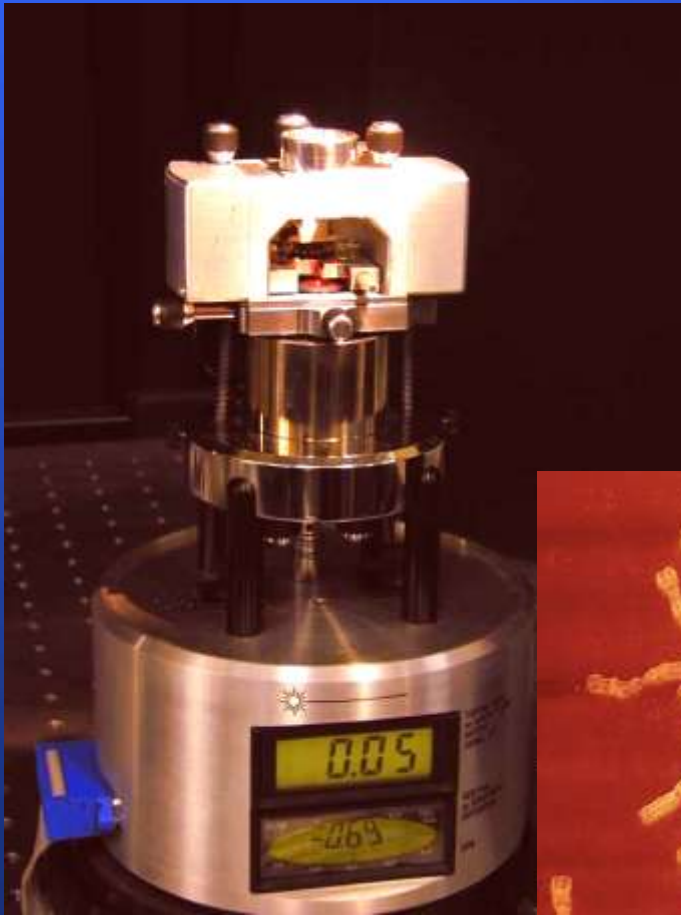
Atomi szerkezet



Elektronszerkezeti hatások

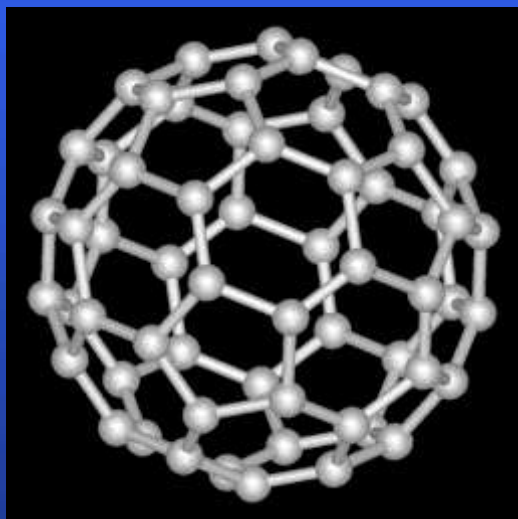


# Atomerő mikroszkóp



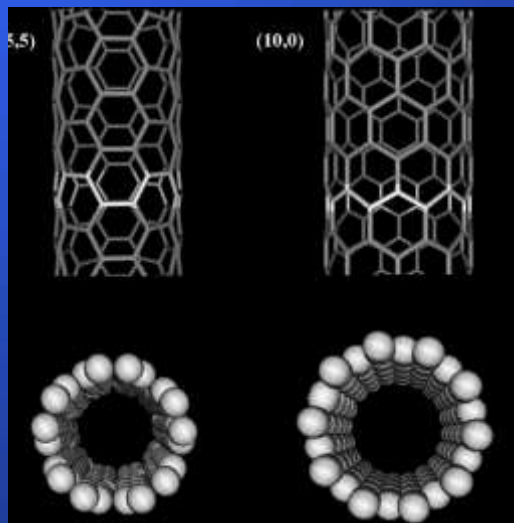
# Szén nanoszerkezetek

Fullerén  
0D



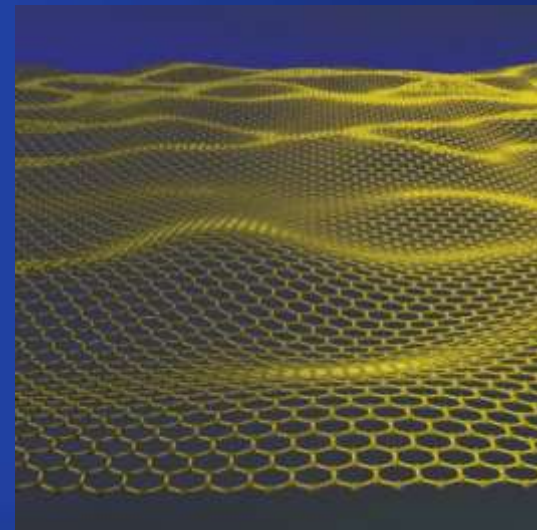
**1985**  
H.W.Kroto

Nanocső  
1D



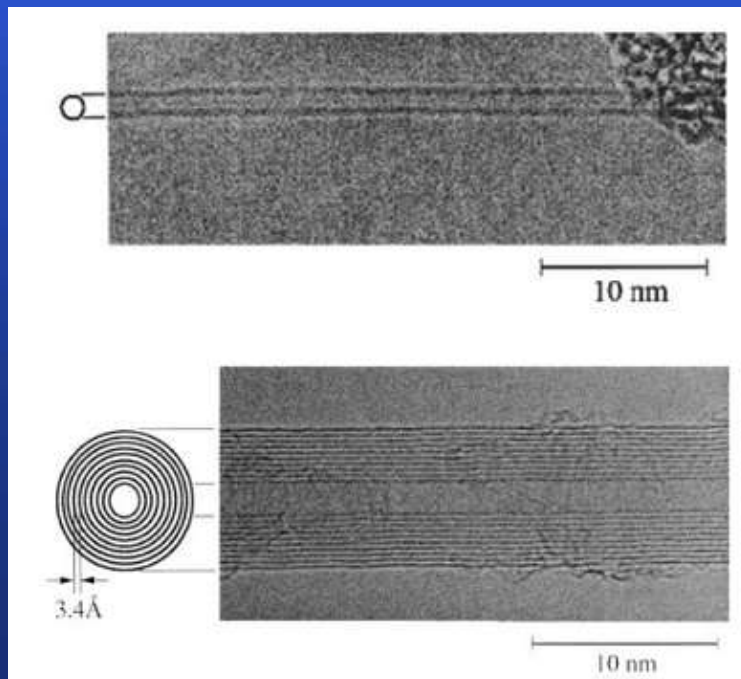
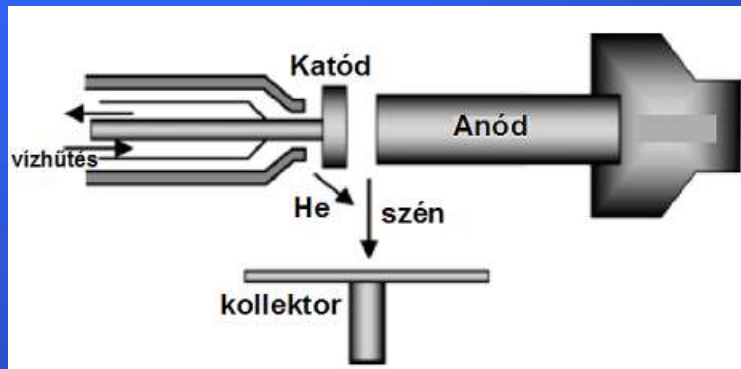
**1991**  
S Iijima

Grafén  
2D

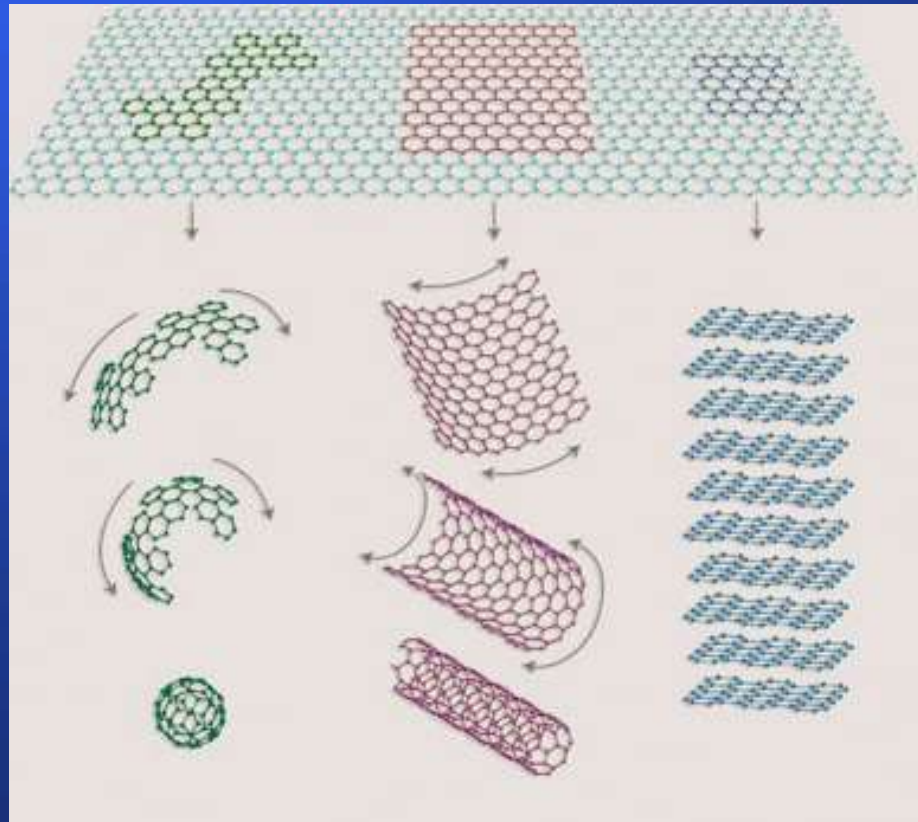


**2004**  
K. S. Novoselov

# Nanocsövek felfedezése

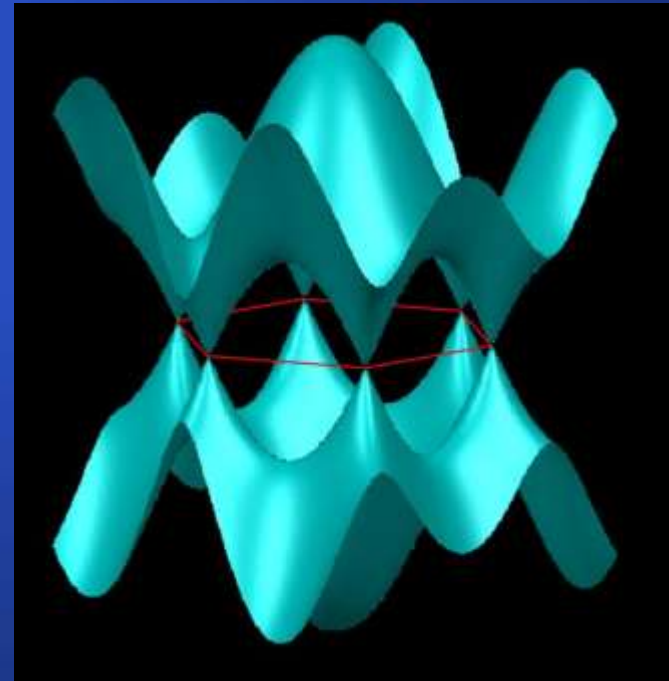
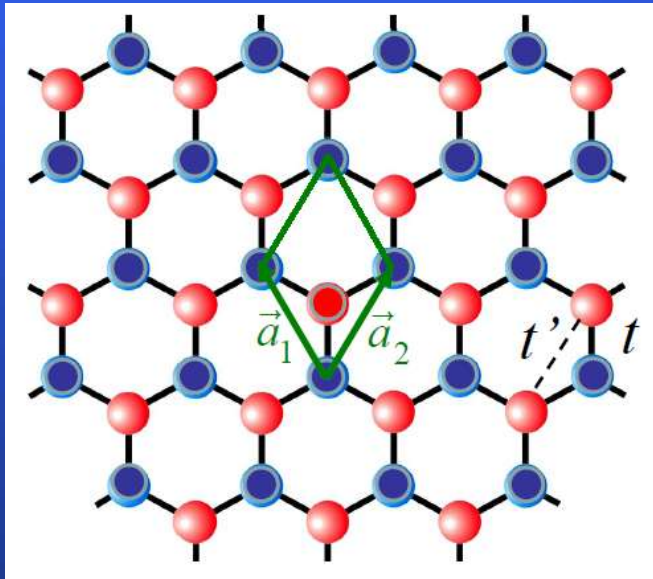


# Kiindulópont: a grafén elektronszerkezete





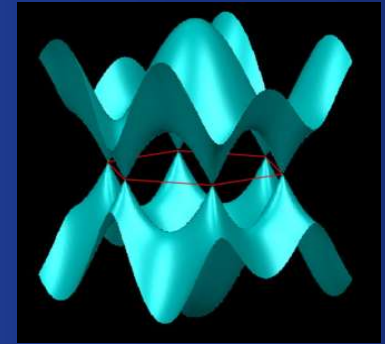
# A grafén elektronszerkezete



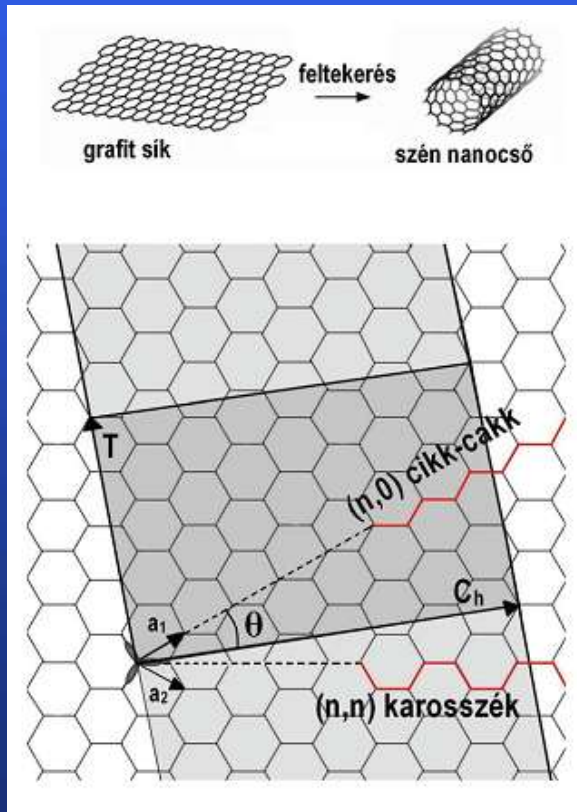
$$E_{2D}(\vec{k}) = \frac{\varepsilon_{2p} \pm \gamma_0 w(\vec{k})}{1 \pm s w(\vec{k})}$$

$$w(\vec{k}) = \sqrt{|f(\vec{k})|^2} = \sqrt{1 + 4 \cos \frac{\sqrt{3}k_x a}{2} \cos \frac{k_y a}{2} + 4 \cos^2 \frac{k_y a}{2}}$$

# Szén nanocsővek elektronszerkezete



$$\bar{C}_h \vec{k} = 2n\pi$$



### Nanotubes - Electronic Properties

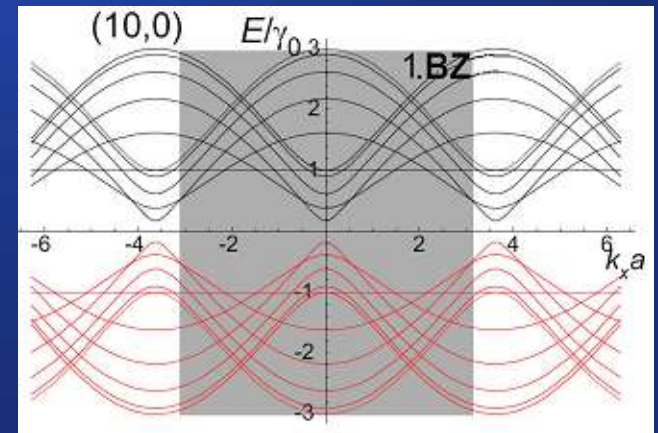
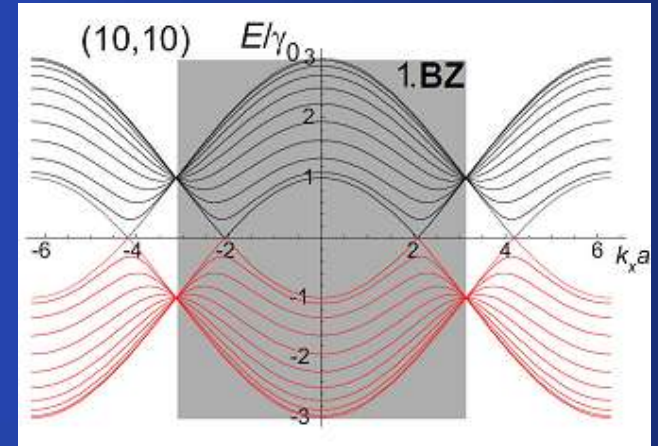
$2\pi k_n R = 2\pi n$

$\Rightarrow$  1D Metal

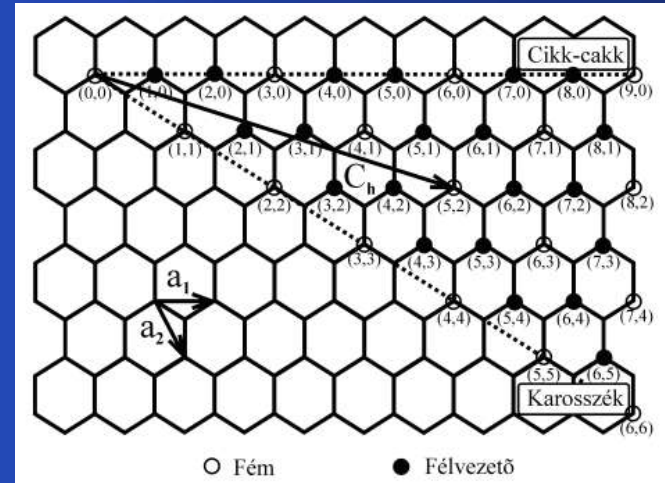
$\Rightarrow$  1D Semiconductor

$E_g = (dE/dk)\Delta k \sim 0.5 \text{ eV}$

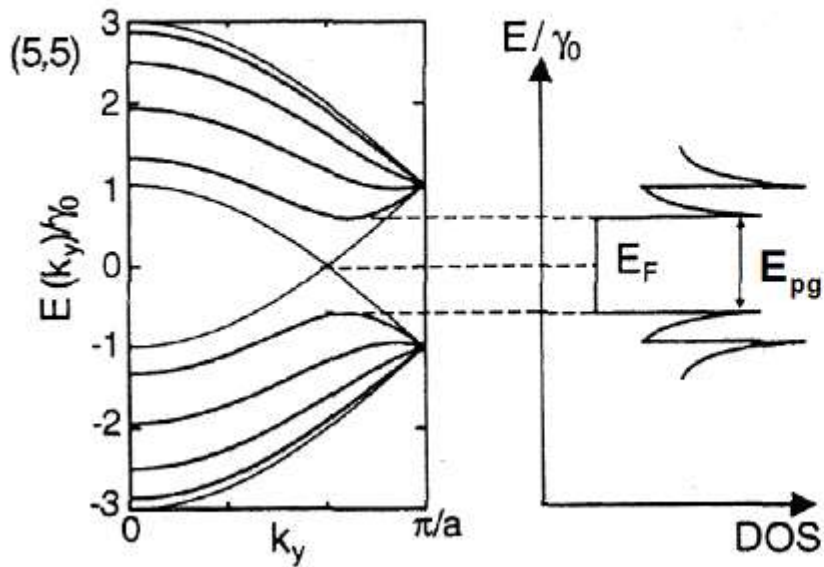
2 1D Subbands



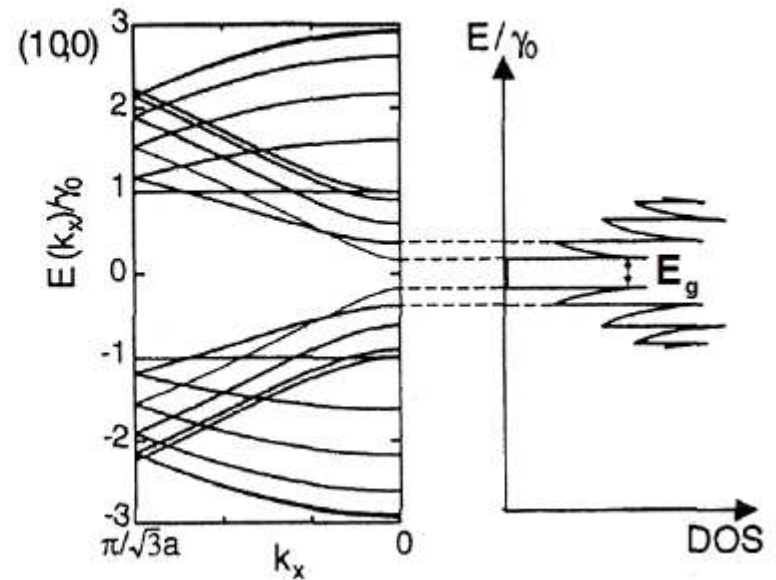
# Fémes vs félvezető nanocsövek



## Fémes cső

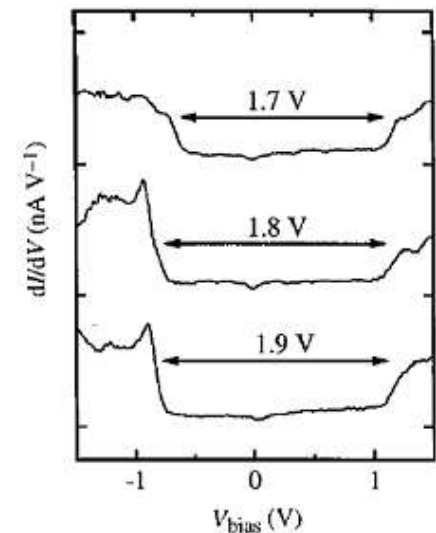
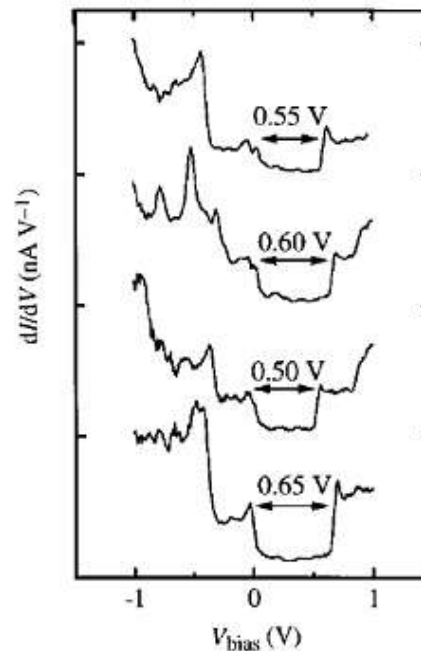
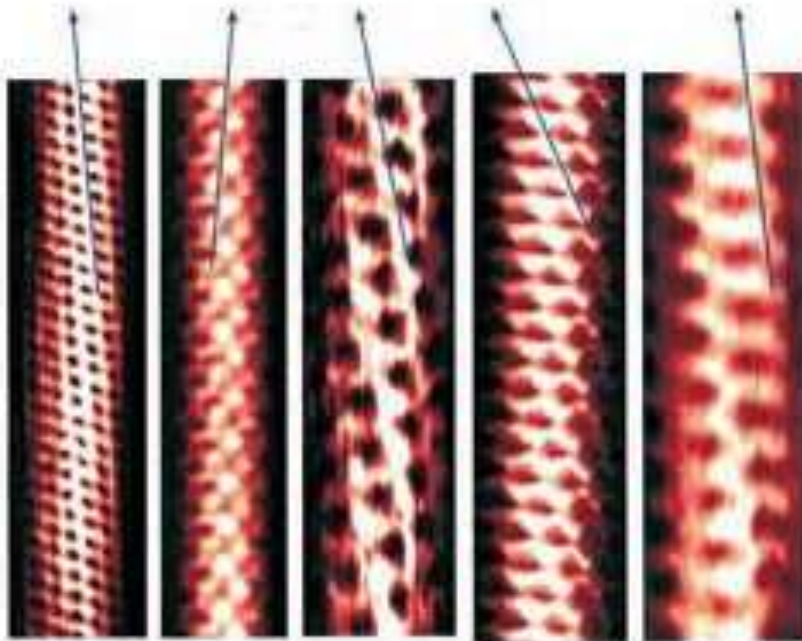
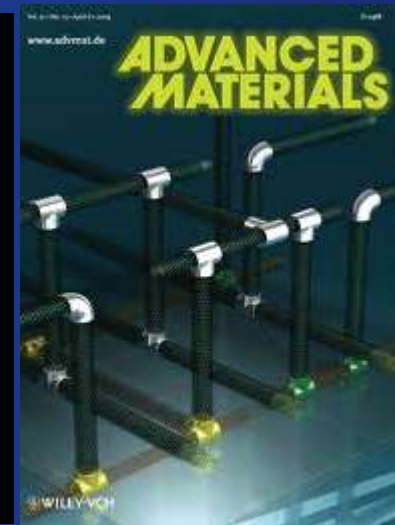
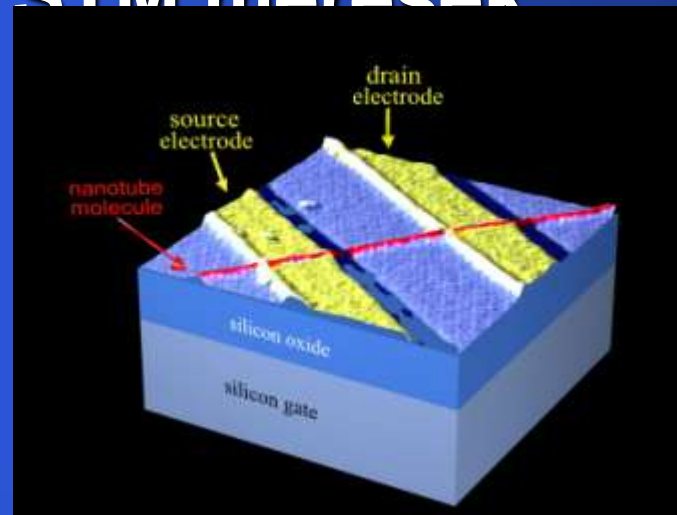


## Félvezető





# Kísérleti igazolás – STM mérések





# Grafén – fizikai Nobel-díj 2010



Andre Geim



Kostya Novoselov

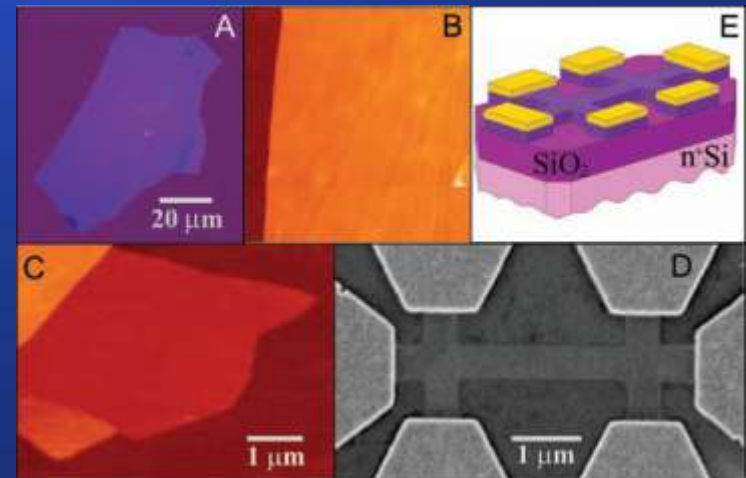
*“for groundbreaking experiments regarding the two dimensional material graphene”*

## Electric Field Effect in Atomically Thin Carbon Films

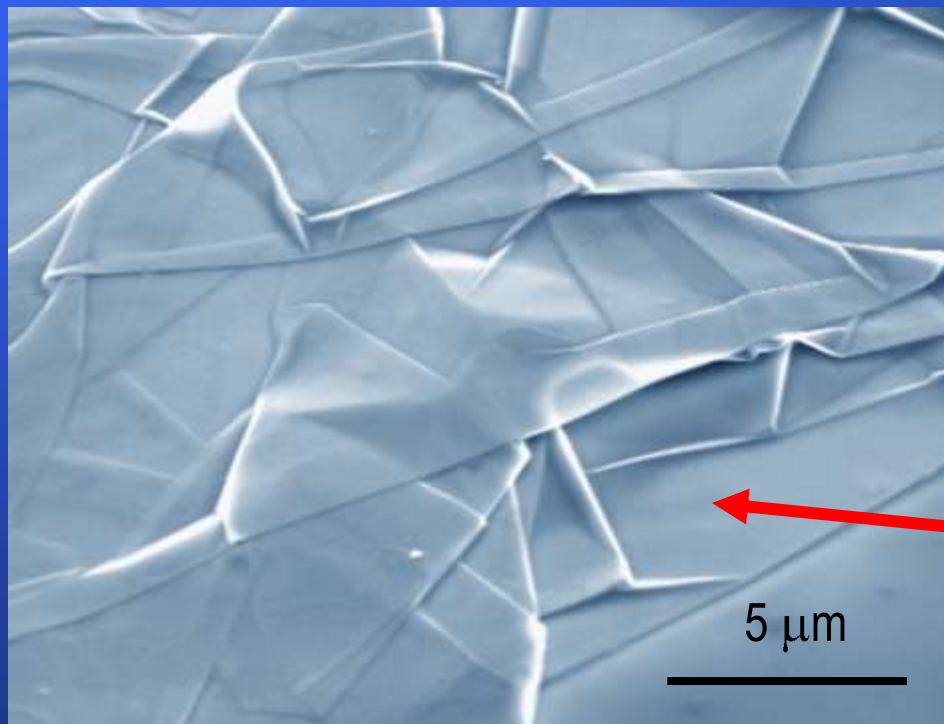
K. S. Novoselov,<sup>1</sup> A. K. Geim,<sup>1\*</sup> S. V. Morozov,<sup>2</sup> D. Jiang,<sup>1</sup>  
Y. Zhang,<sup>1</sup> S. V. Dubonos,<sup>2</sup> I. V. Grigorieva,<sup>1</sup> A. A. Firsov<sup>2</sup>

We describe monocrystalline graphitic films, which are a few atoms thick but are nonetheless stable under ambient conditions, metallic, and of remarkably high quality. The films are found to be a two-dimensional semimetal with a tiny overlap between valence and conduction bands, and they exhibit a strong ambipolar electric field effect such that electrons and holes in concentrations up to  $10^{13}$  per square centimeter and with room-temperature mobilities of  $\sim 10,000$  square centimeters per volt-second can be induced by applying gate voltage.

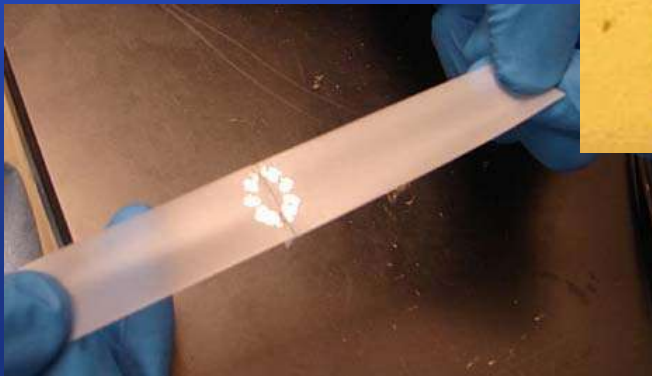
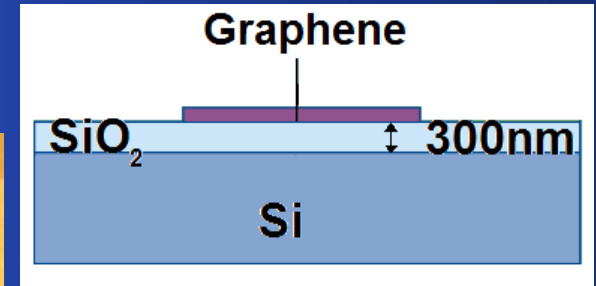
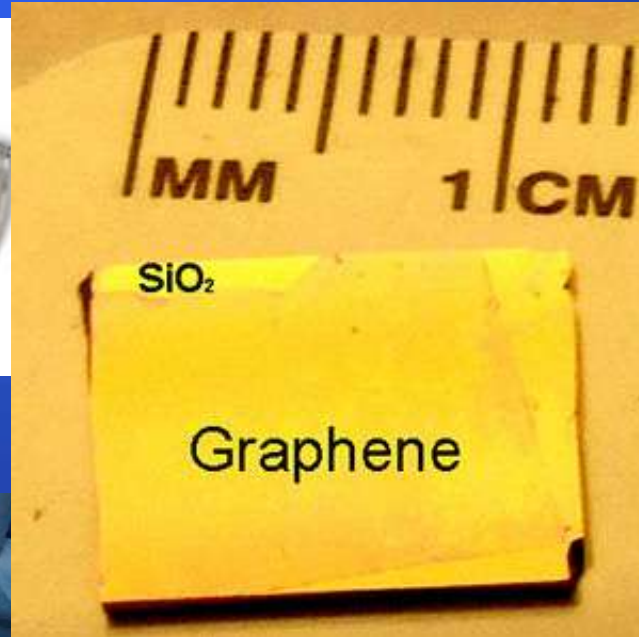
22 OCTOBER 2004 VOL 306 SCIENCE [www.sciencemag.org](http://www.sciencemag.org)



# Hogyan állítjuk elő?

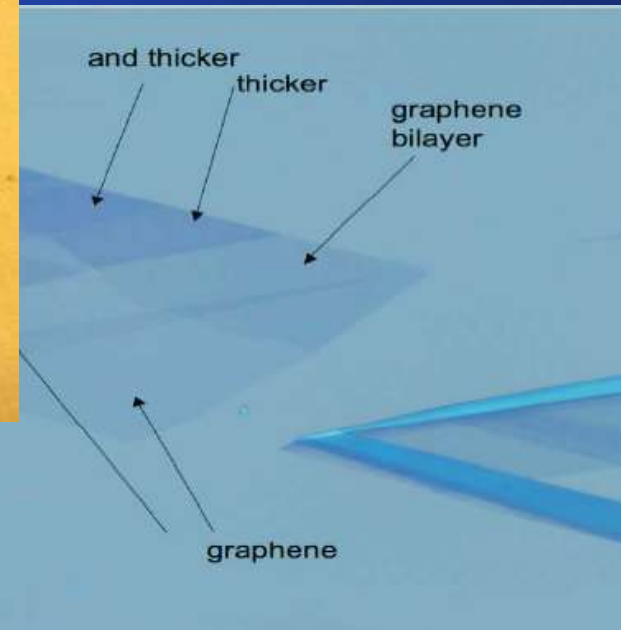


# Hogyan azonosítjuk ?



essentially graphite

oxidized Si wafer  
This is the reference colour

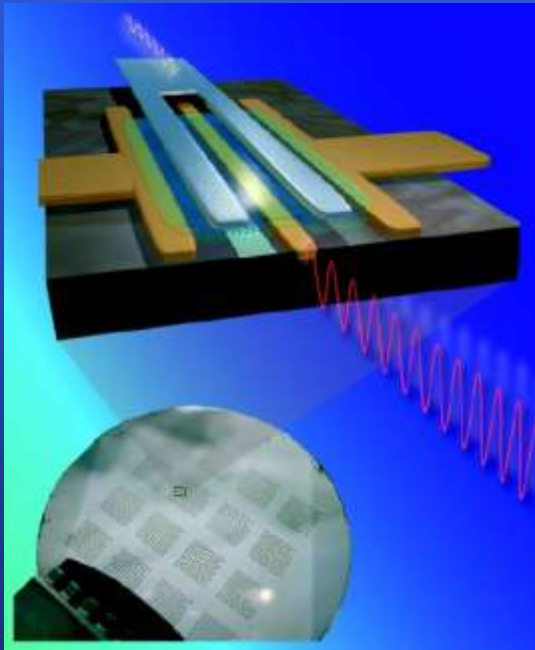




# Tulajdonságai

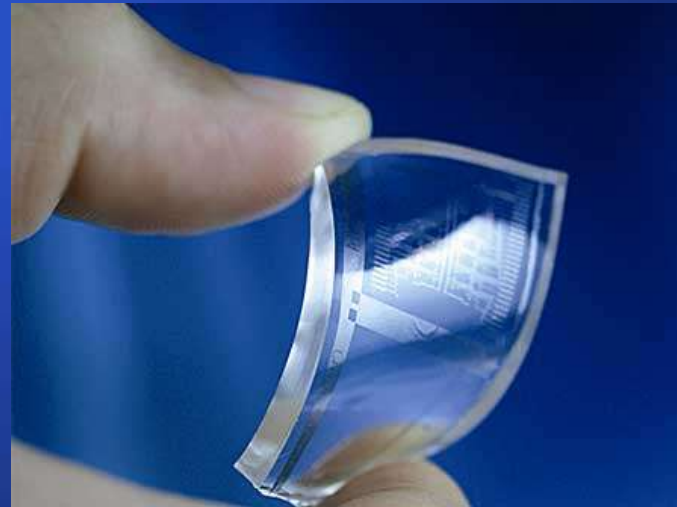
## Elektromos tulajdonságok:

- töltéshordozók mobilitása  $> 200000 \text{ cm}^2/\text{Vs}$  (Si:  $<1500 \text{ cm}^2/\text{Vs}$ )
- disszipáció-mentes transzport mikronos távolságokon



**tranzisztor @ 300 GHz**

Nature **467**, 305 (2010)



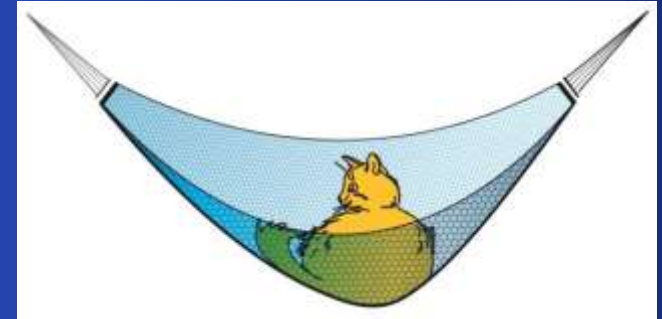
**flexibilis, átlátszó elektronika**

*Nature* **457**, 706 (2009)

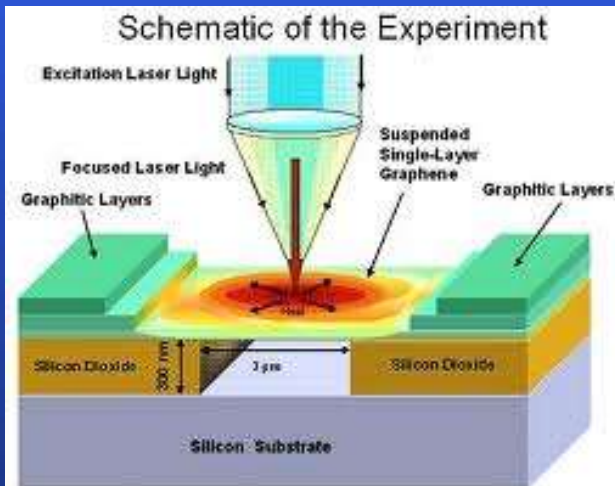


# Termális és mechanikai tulajdonságai

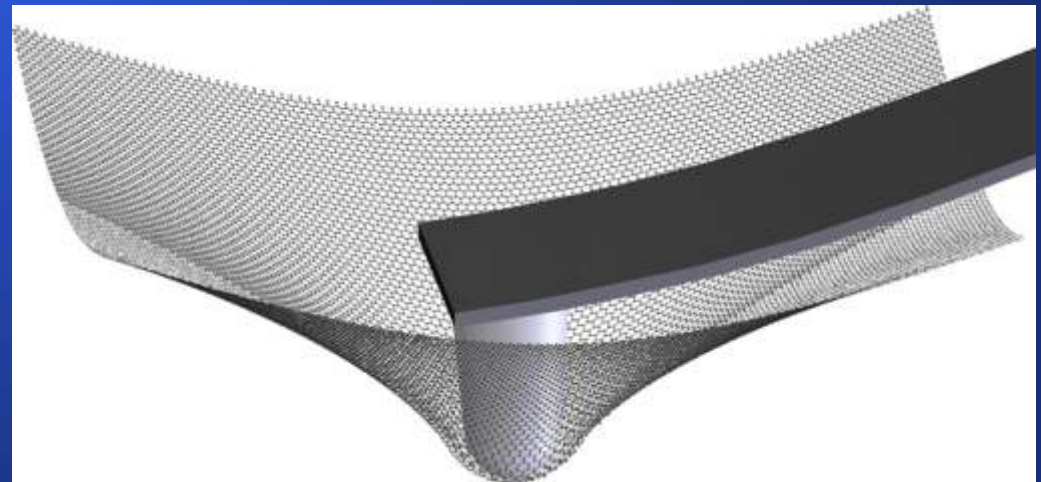
Hővezetési együttható  $5000 \text{ Wm}^{-1}\text{K}^{-1}$   
(réz  $400 \text{ Wm}^{-1}\text{K}^{-1}$ )



Science **321**, 385 (2008)



Nano Lett. **8**, 902 (2008)



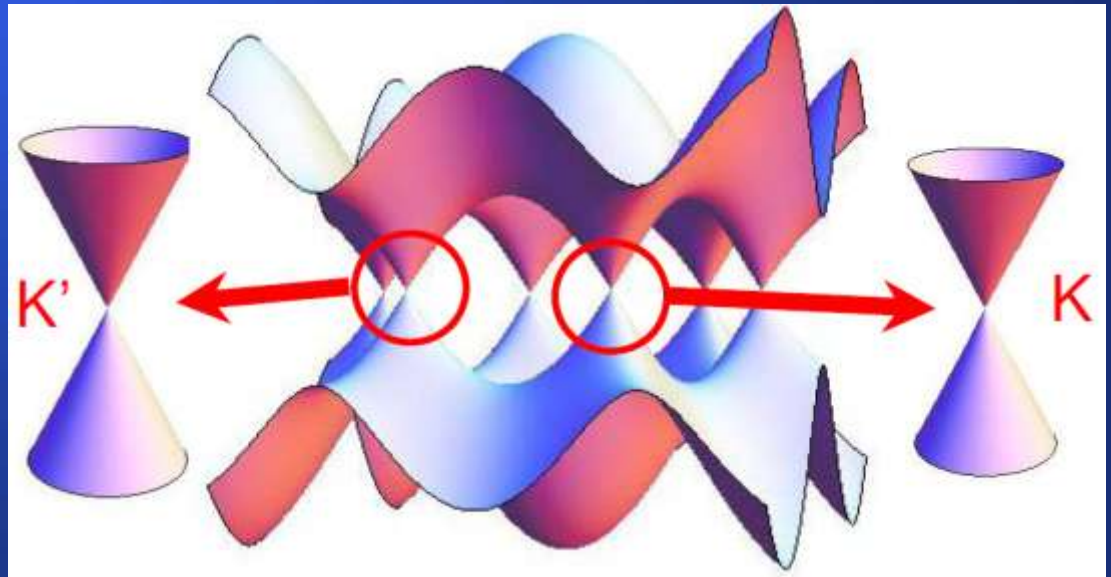
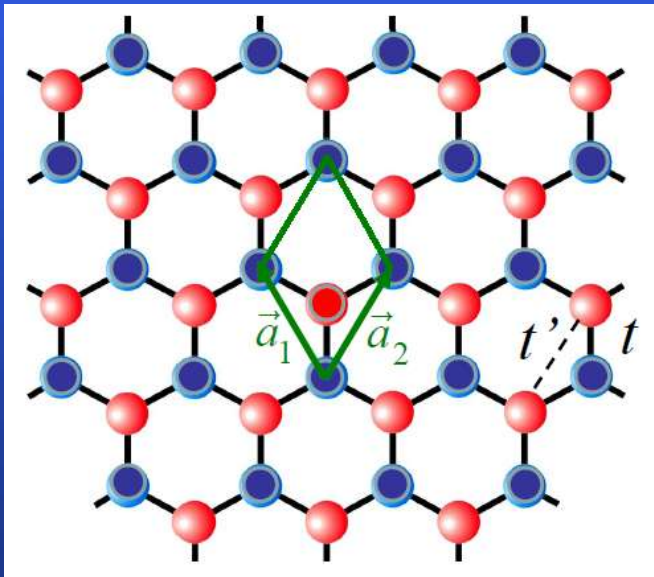
„legerősebb” anyag

$$\rho = 0.77 \text{ mg/m}^2$$

# A grafén fizikája

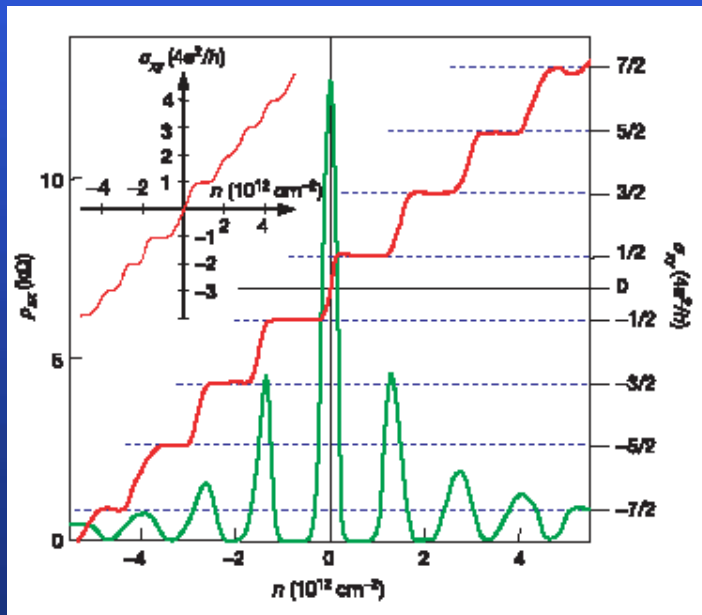
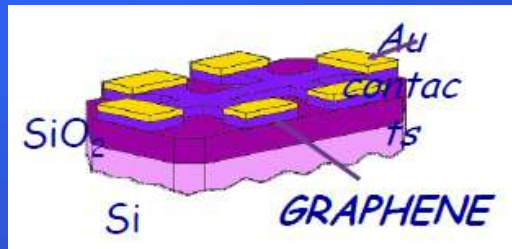
- nulla tiltott sávú félvezető

Phys. Rev. 71, 622 (1947)

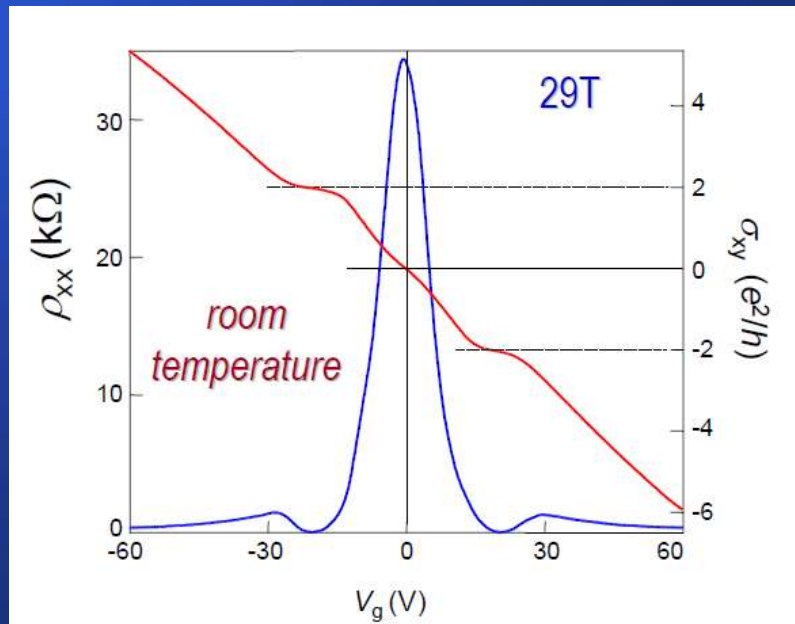


Lineáris diszperzió a Fermi szint közelében – zérus tömegű töltéshordozók  
- QED

# Kísérleti ellenőrzés – Kvantum Hall effektus



Nature 438, 197 (2005)



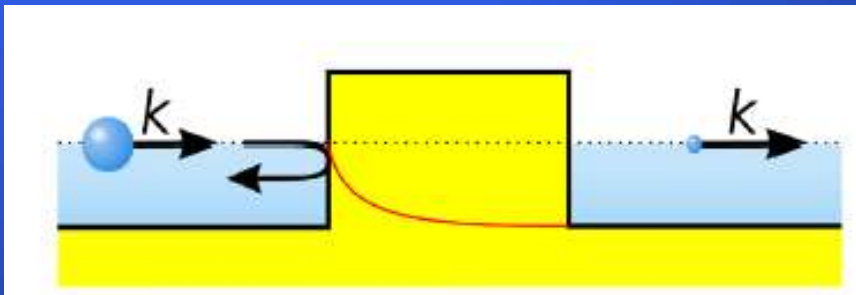
Science 315, 1379 (2007)

# A Klein paradoxon

Relativisztikus jelenségek tanulmányozása laborban

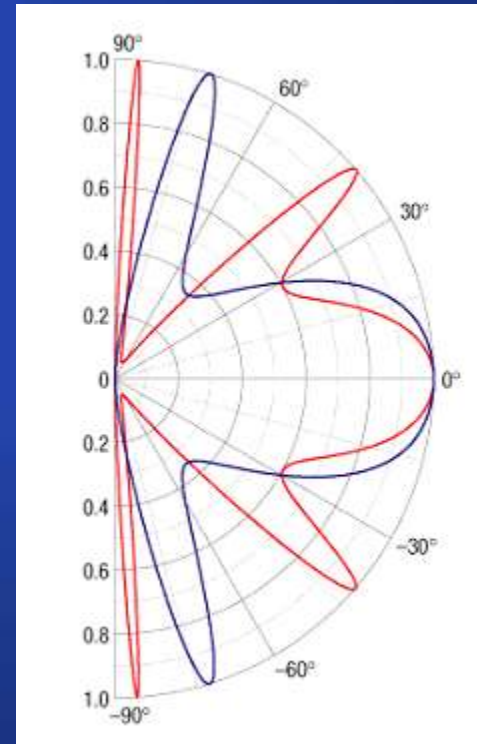
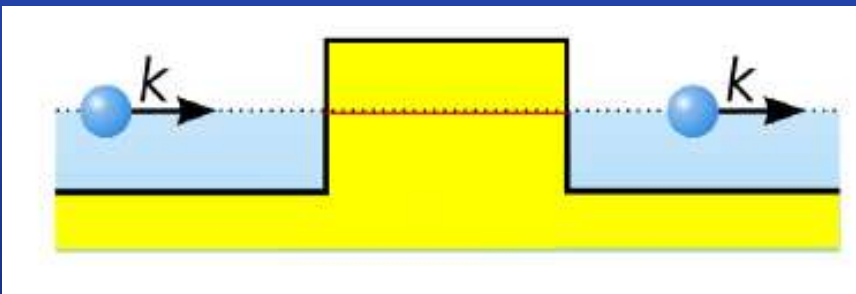
## Kvantum mechanika

$T \ll 1$



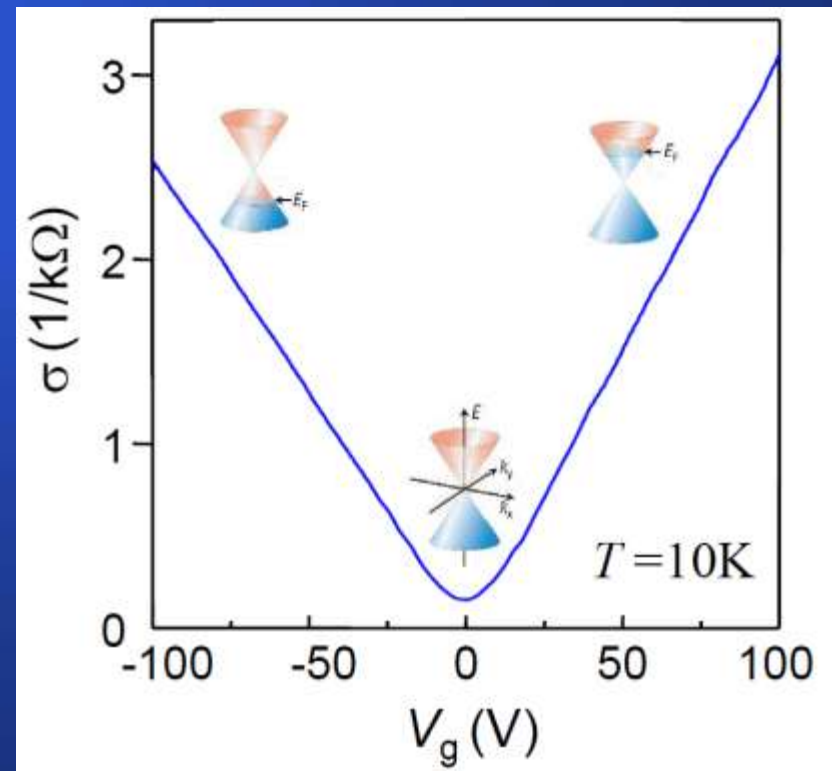
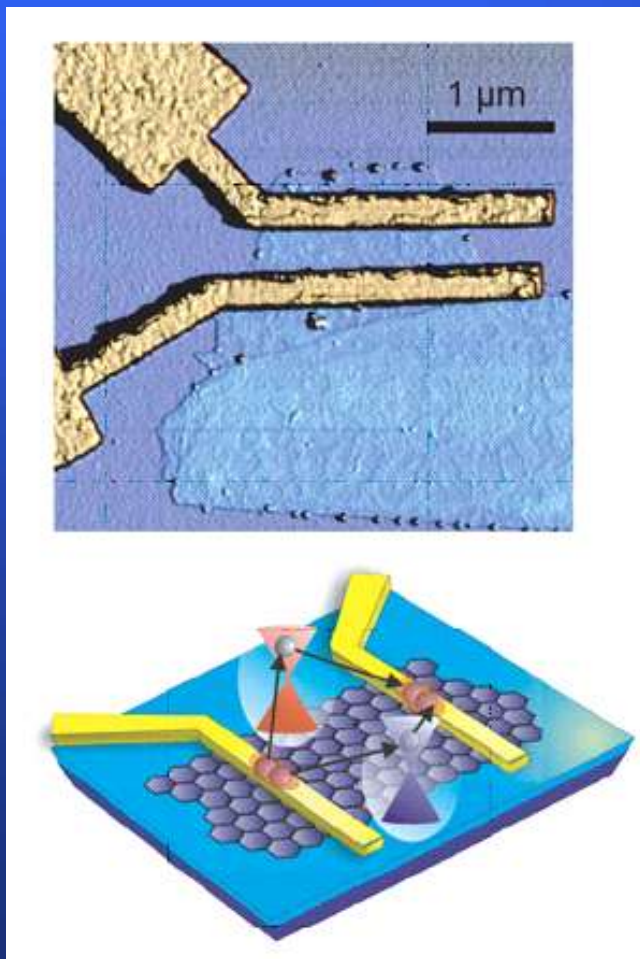
## Kvantum elektrodinamika

$T = 1$





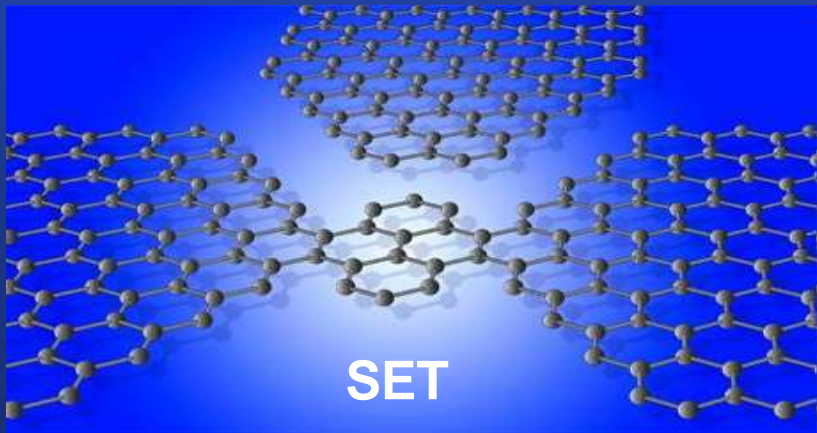
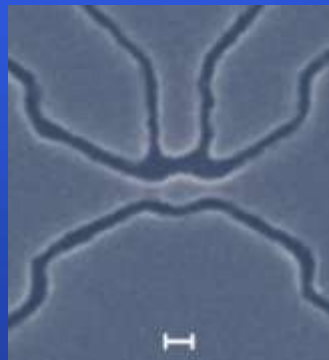
# A grafén vezetőképessége



# Grafén nanoszerkezetek

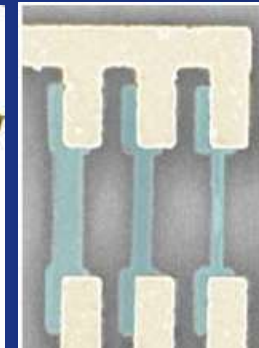
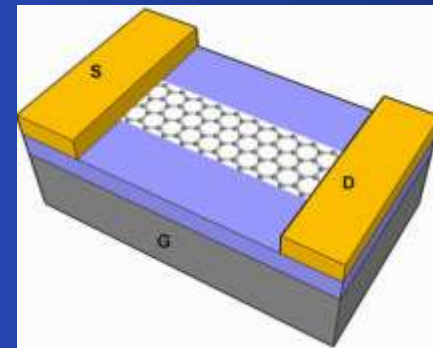
- Tiltott sáv létrehozása
- Él-hatások

## Graphene quantum dots

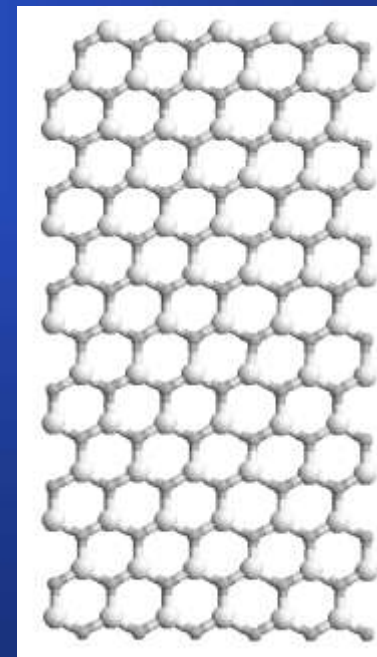


SET

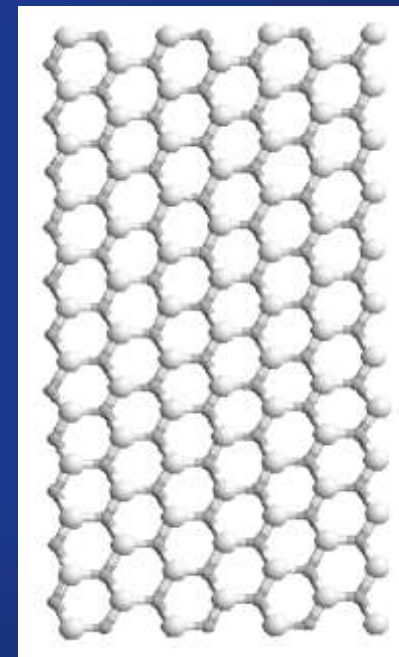
## FET



## Graphene nanoribbons



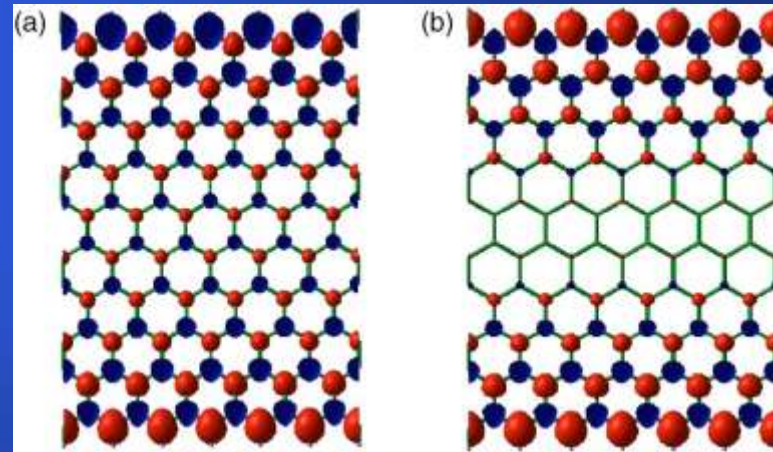
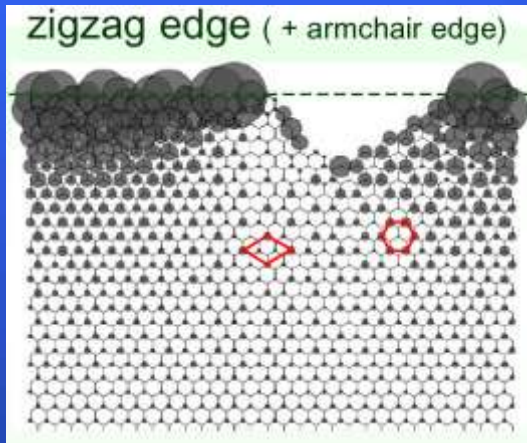
armchair



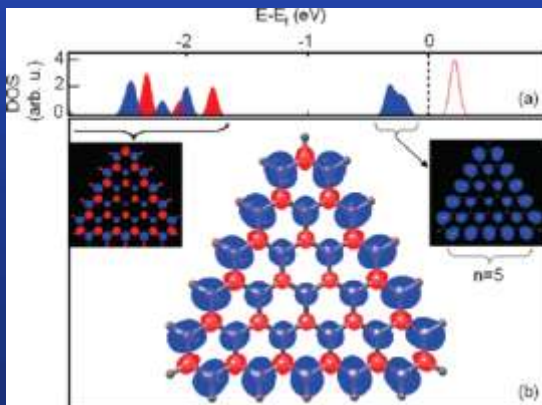
zigzag

# A grafén éleinek fizikája

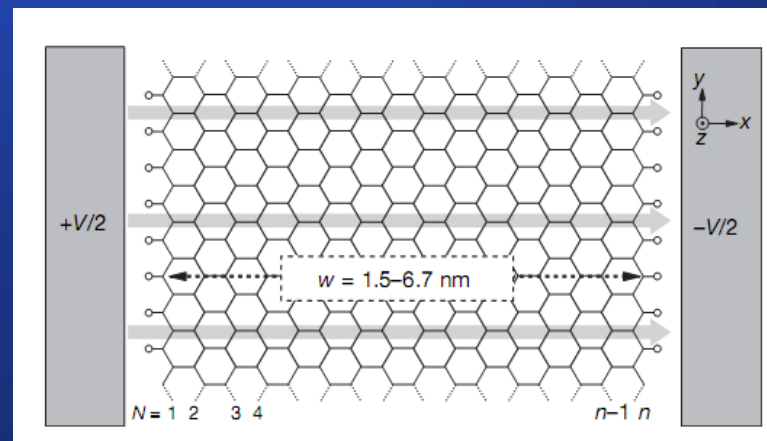
L. Pisani, Phys. Rev. B 75, 064418 (2007)



W.L Wang, Nano Lett. 8, 241 (2008)

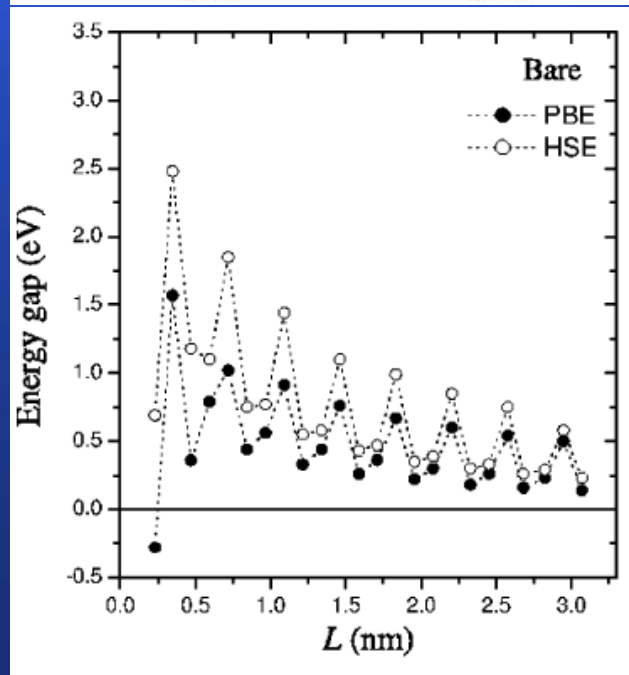
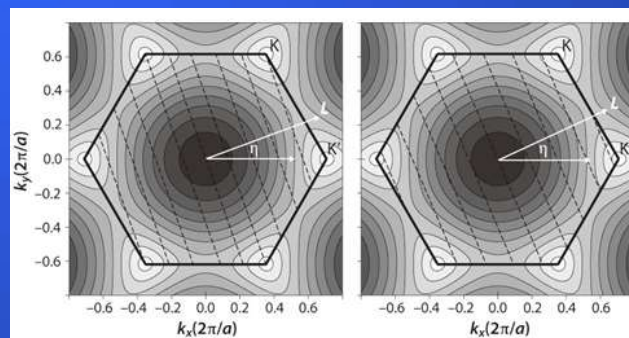
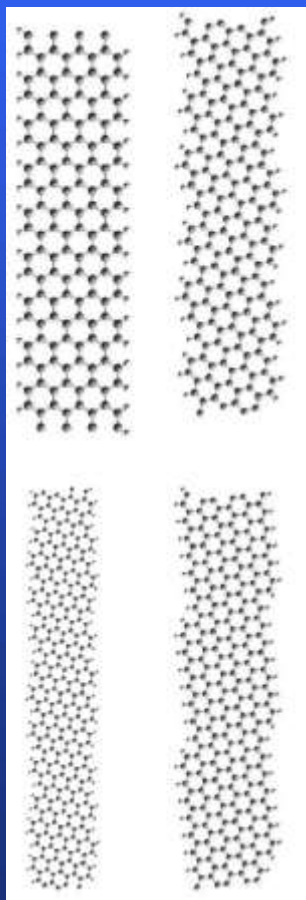


Y.V. Son Nature 444, 347 (2006)

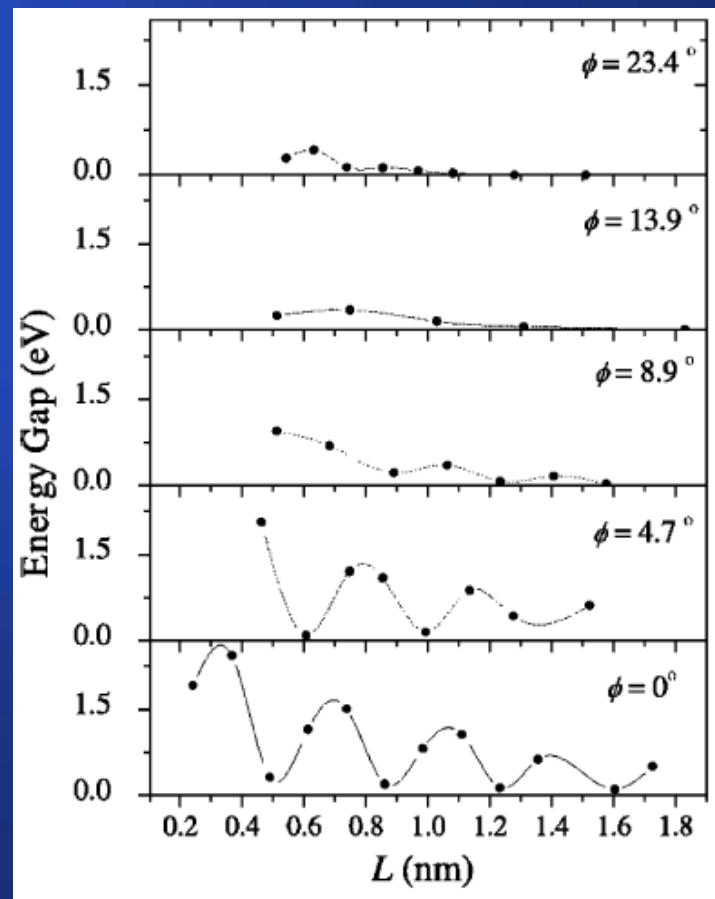




# Grafén nanoszalagok – tiltott sáv

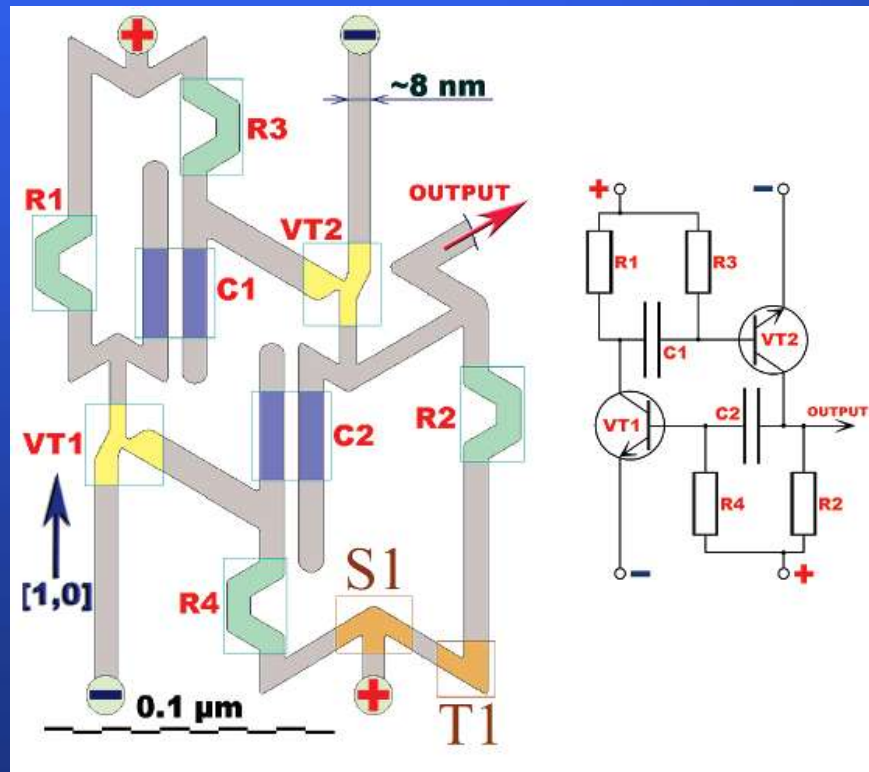


Nano Lett. 6, 2748 (2006)



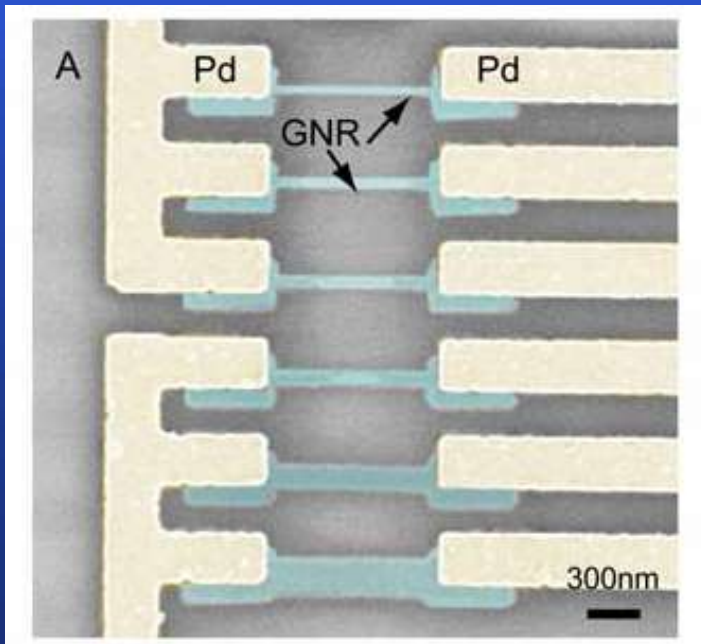
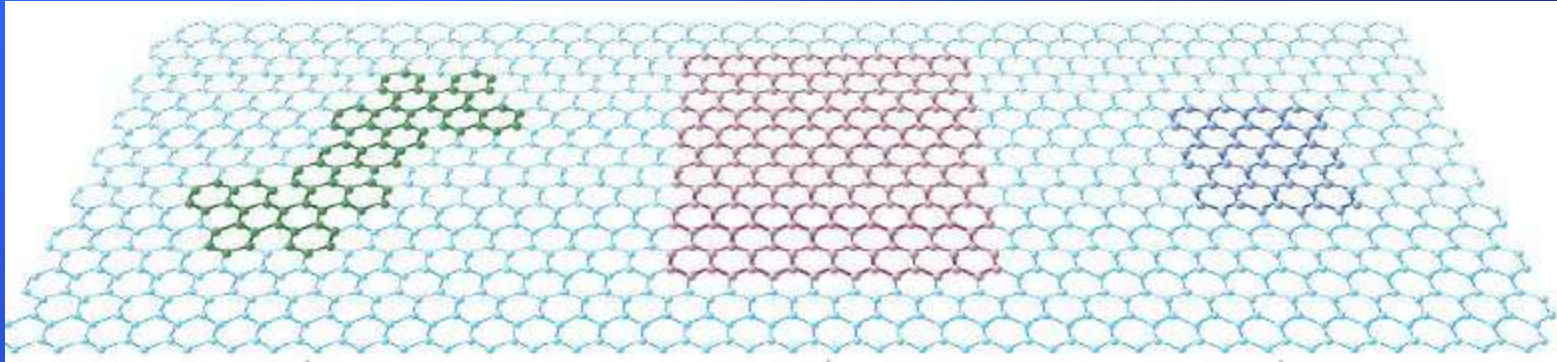


# Grafén elektronika



- Miniaturizálás – magasabb fokú integrálhatóság
- Gyorsabb eszközök
- Kiseb fogyasztás
- Nagyobb adatfeldolgozási kapacitás

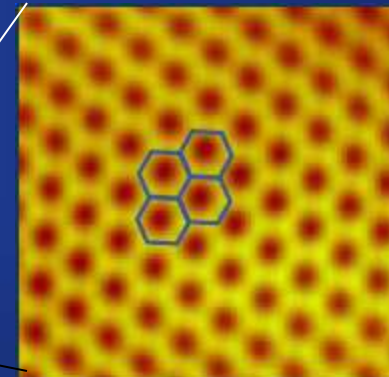
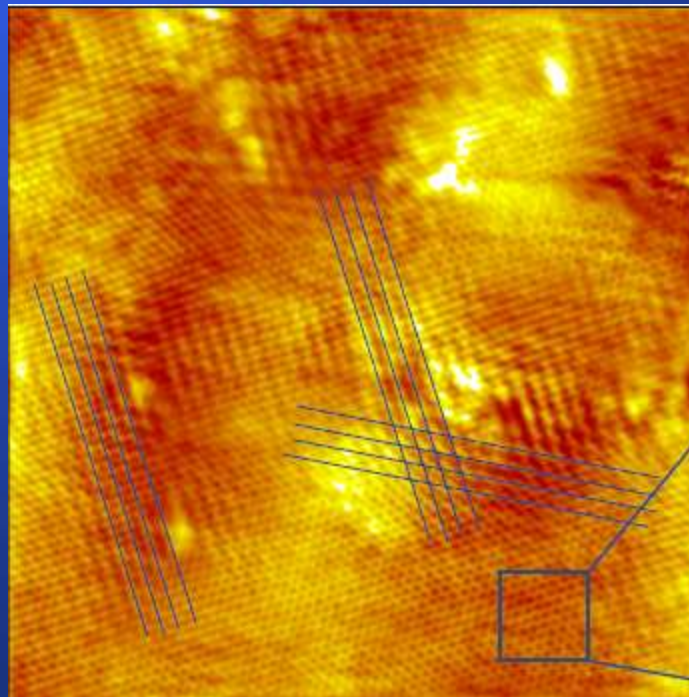
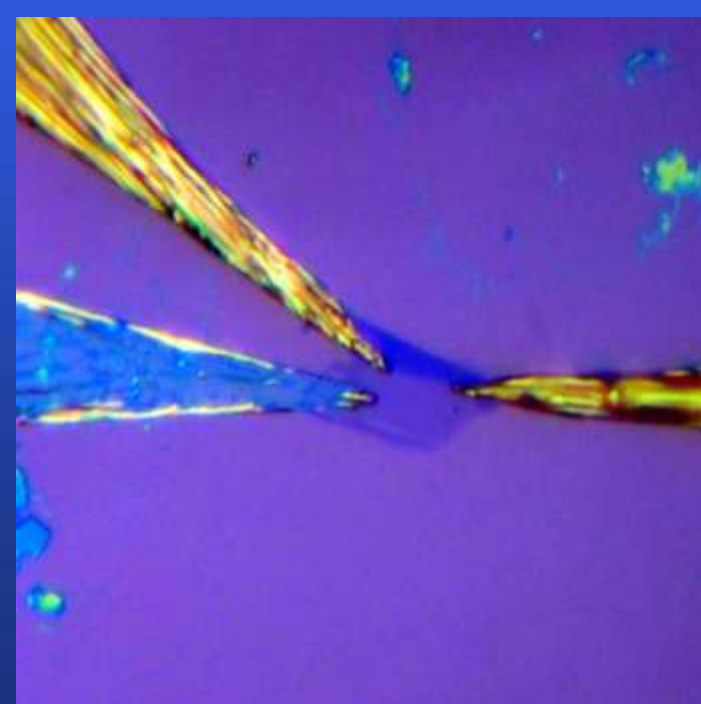
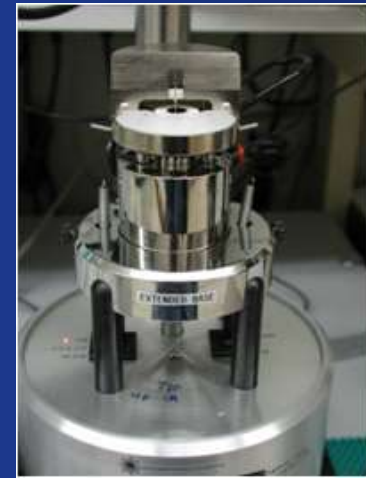
# Grafén nanoszerkezetek előállítása



## Elektronsugaras litográfia

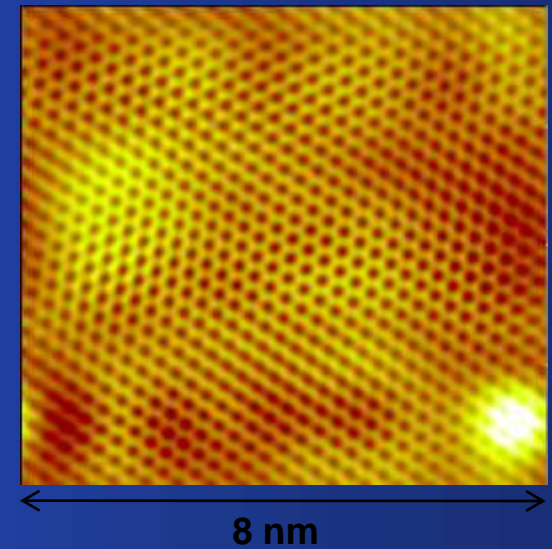
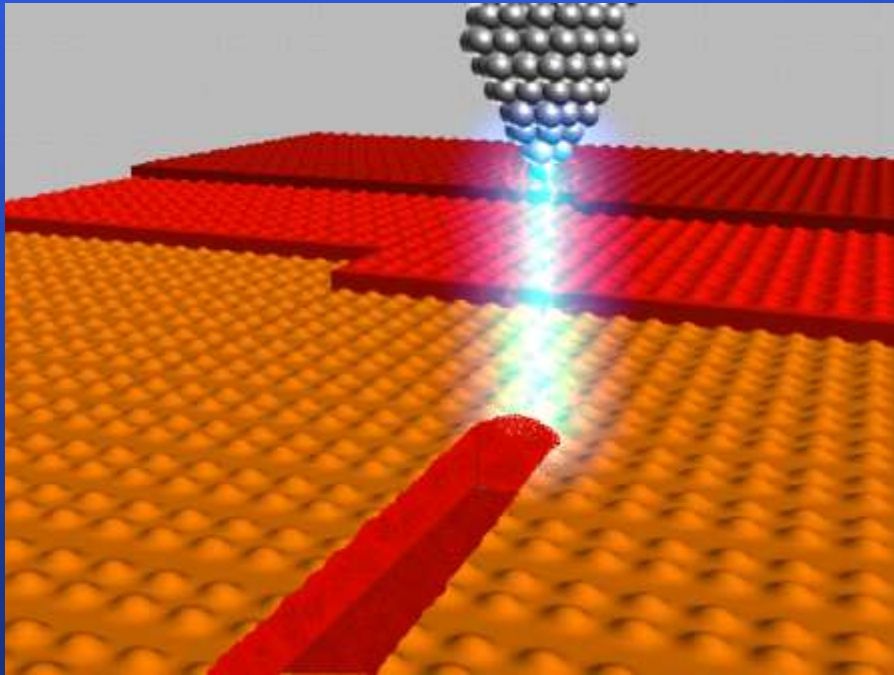
- a szalagok éleinek típusa nem kontrollálható
- minimális szalagszélesség  $> 15$  nm
- „rojtos” szélek

# Grafén STM leképezése





# STM Litográfia

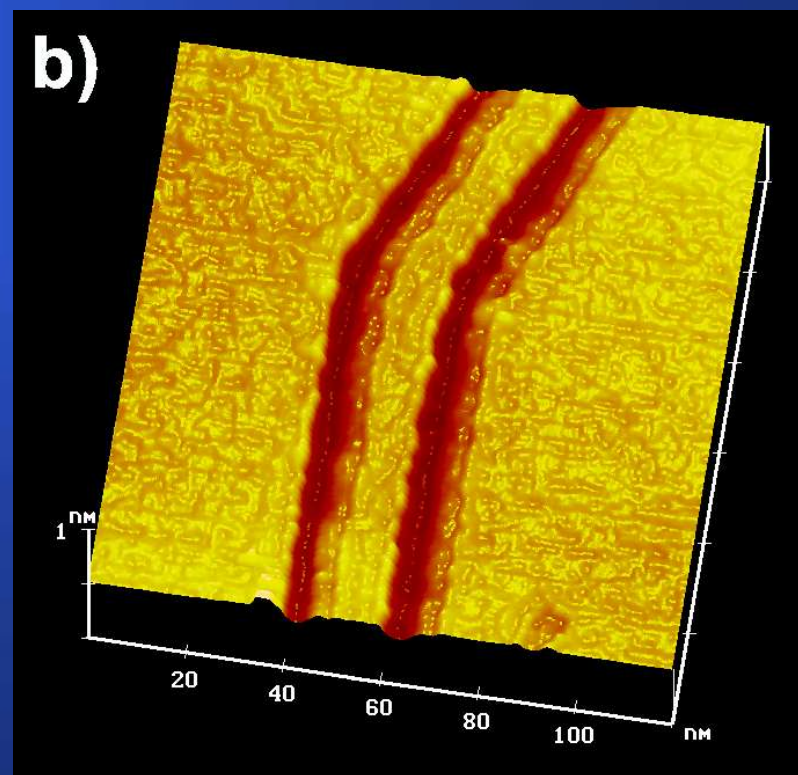
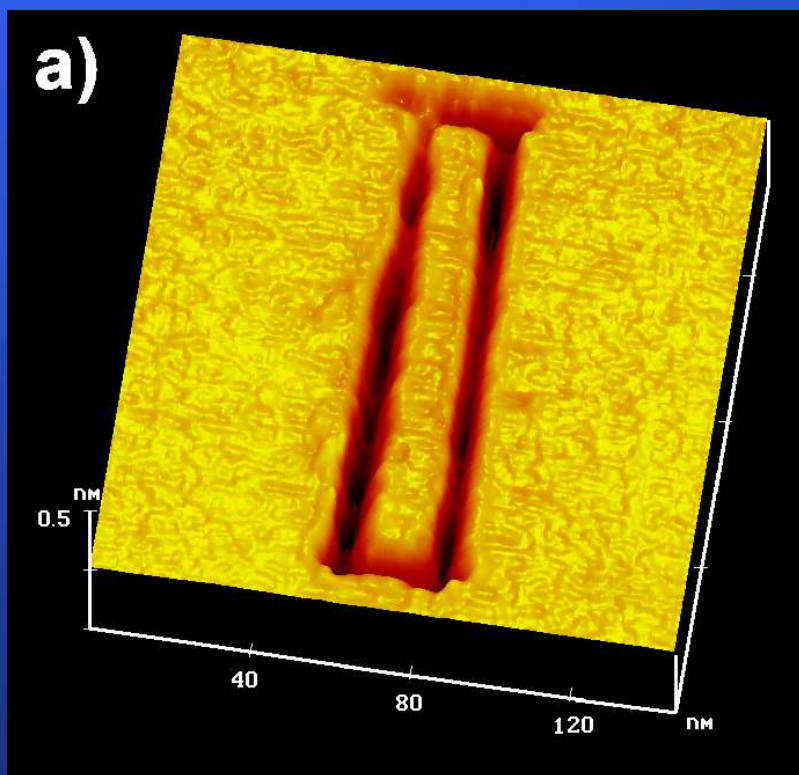


- Lokális módosítás – vágás
- Atomi felbontás
- Az élek orientációjának beállítása
- Atomi szinten pontos mozgítás
- Nanométeres pontosság

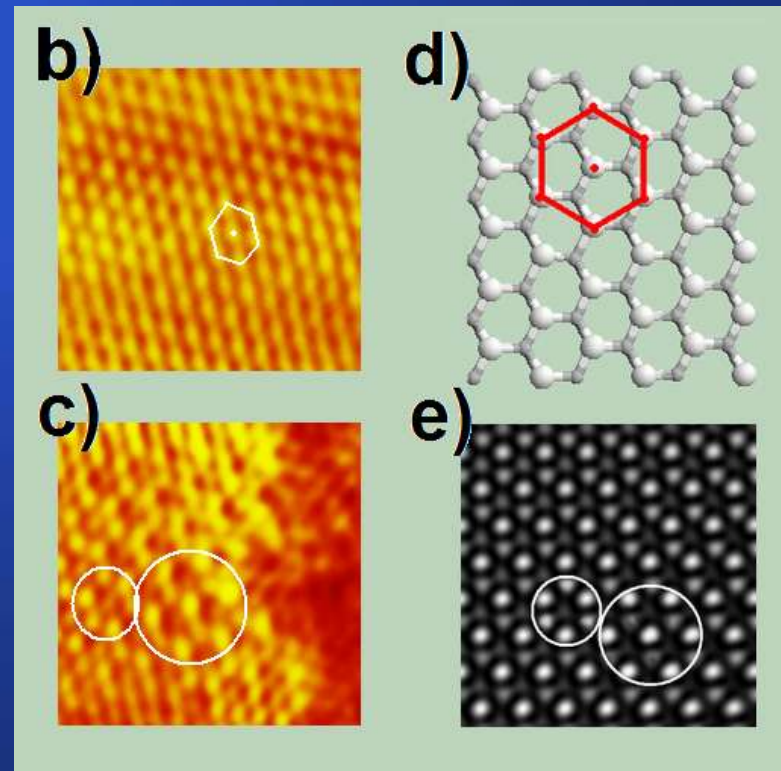
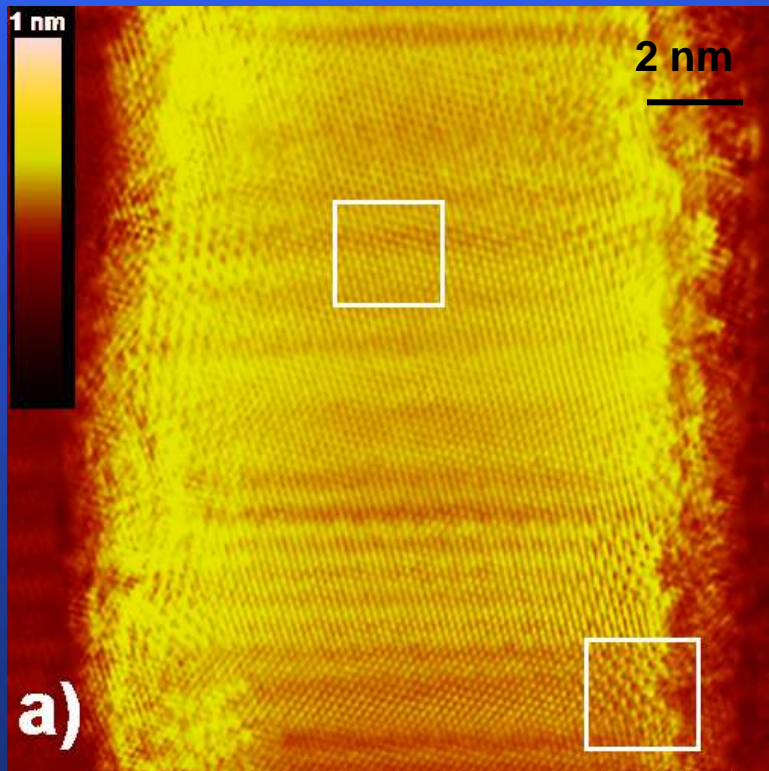




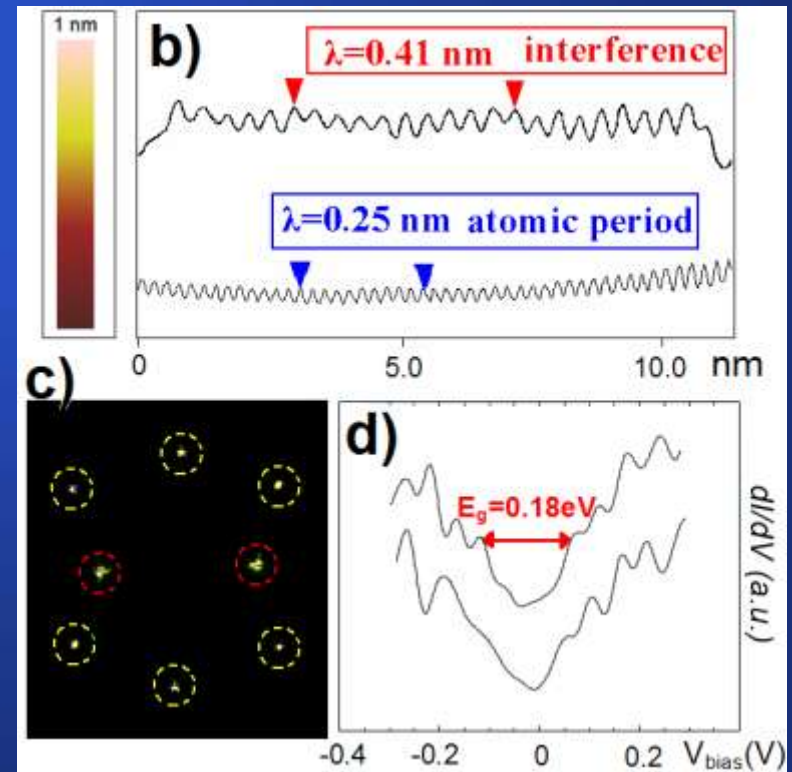
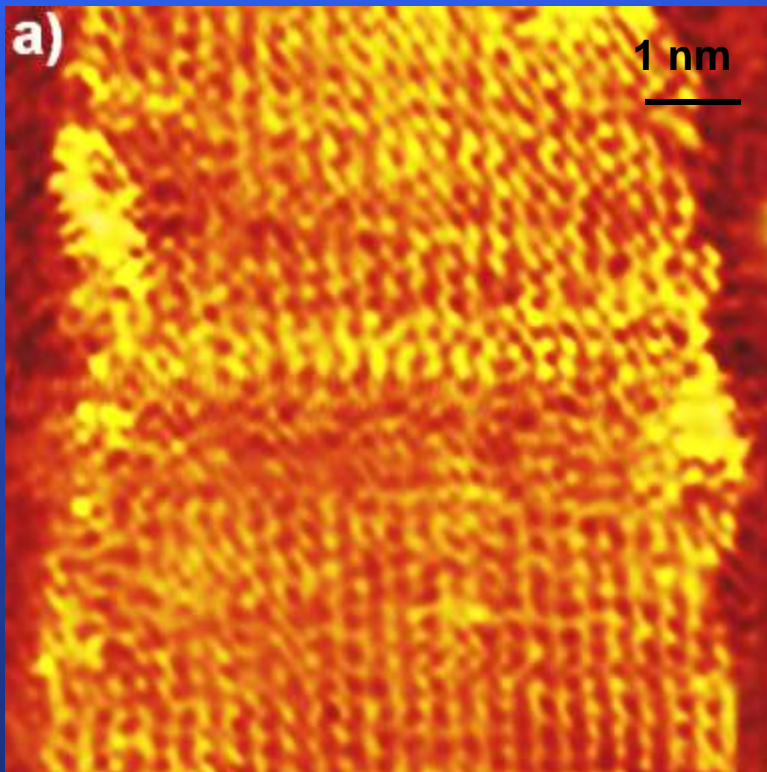
# Grafén nanoszlagok létrehozása STM litográfiával



# Grafén nanoszalagok szerkezete

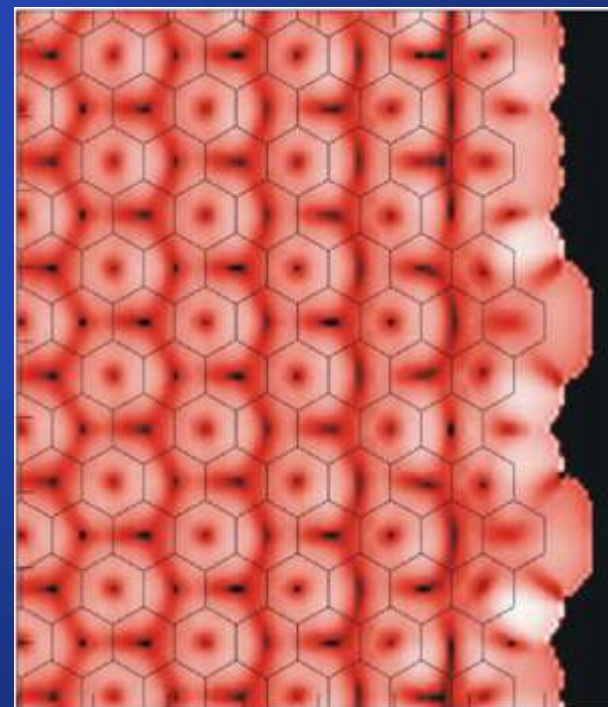
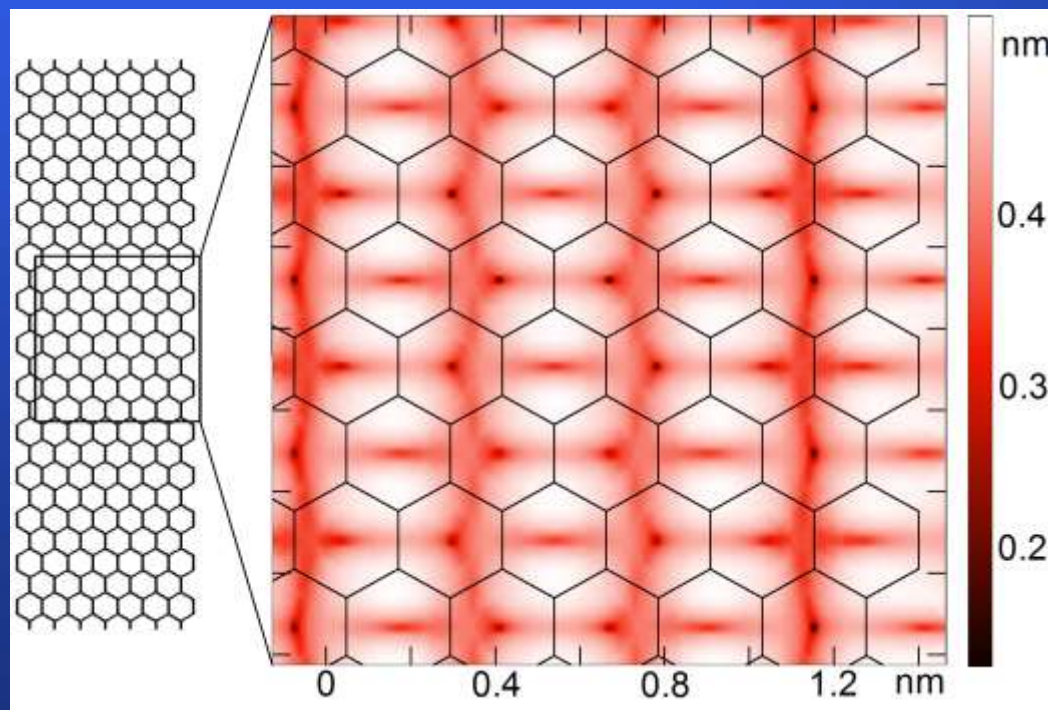


# Elektron állóhullám grafénban



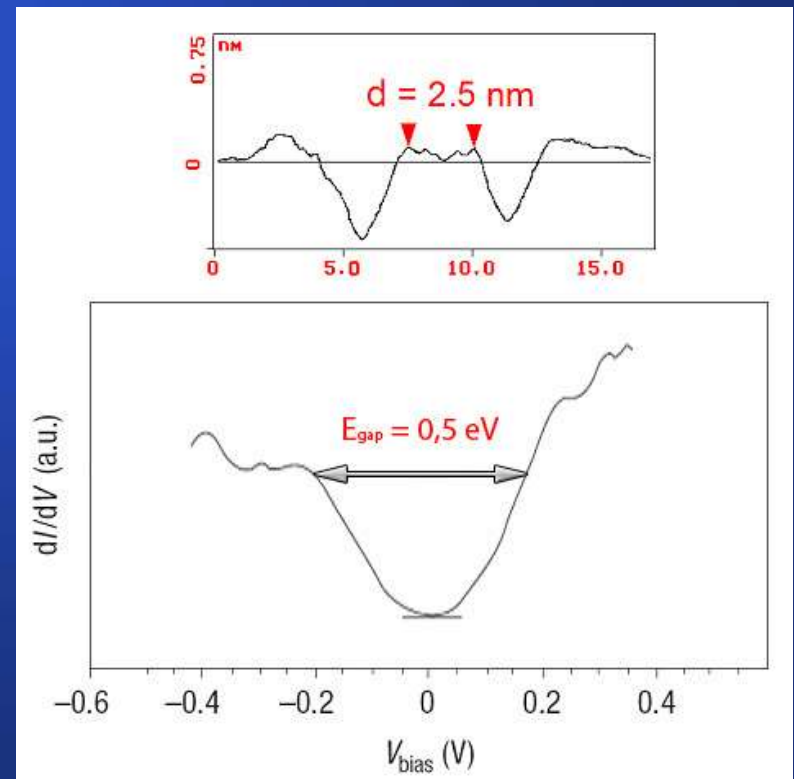
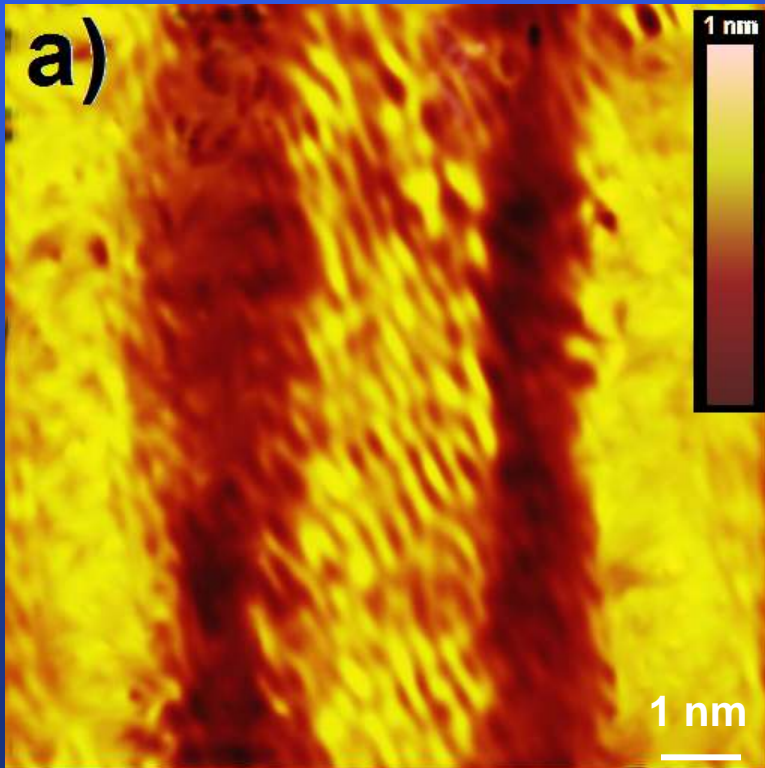


# Elméleti STM képek





# A létező legpontosabb nanomegmunkálási módszer



# Mit hoz a jövő?



**közel**

**távol**

